

Study of GEM-TPC for ILC in Japan

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Requirements @ILC

ILC-TPC

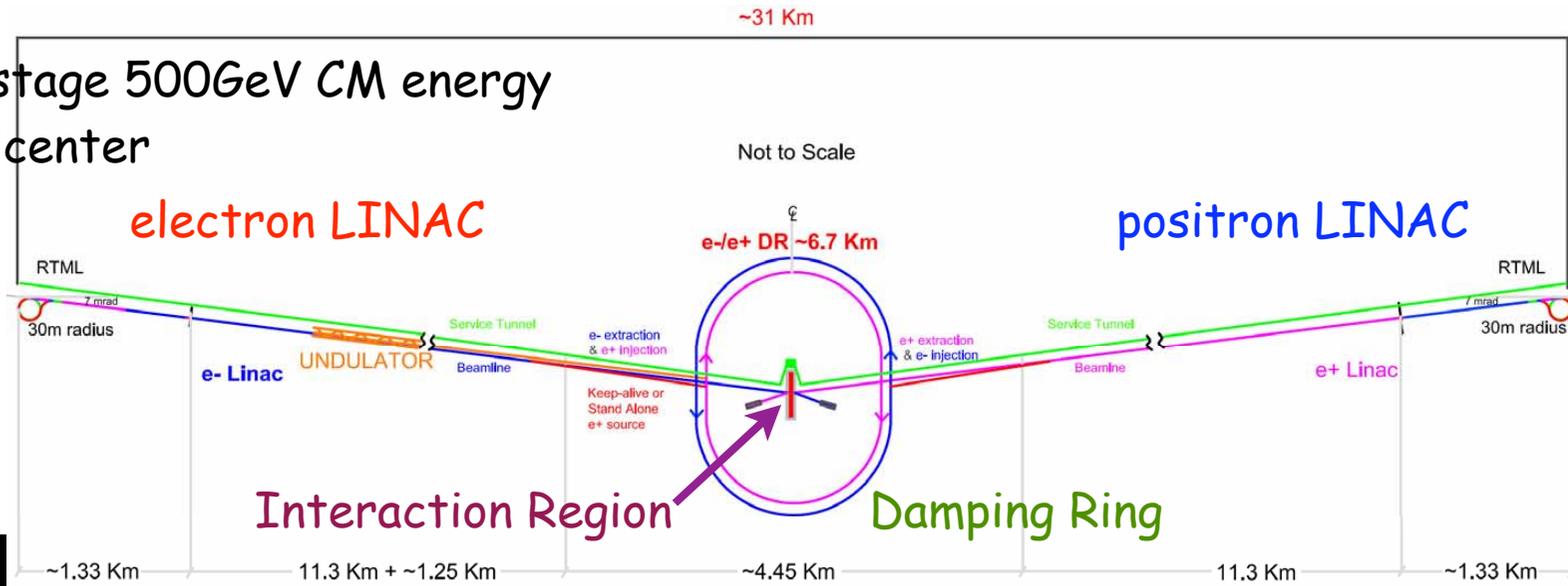
results of small prototype test

GEM endplate for Large Prototype

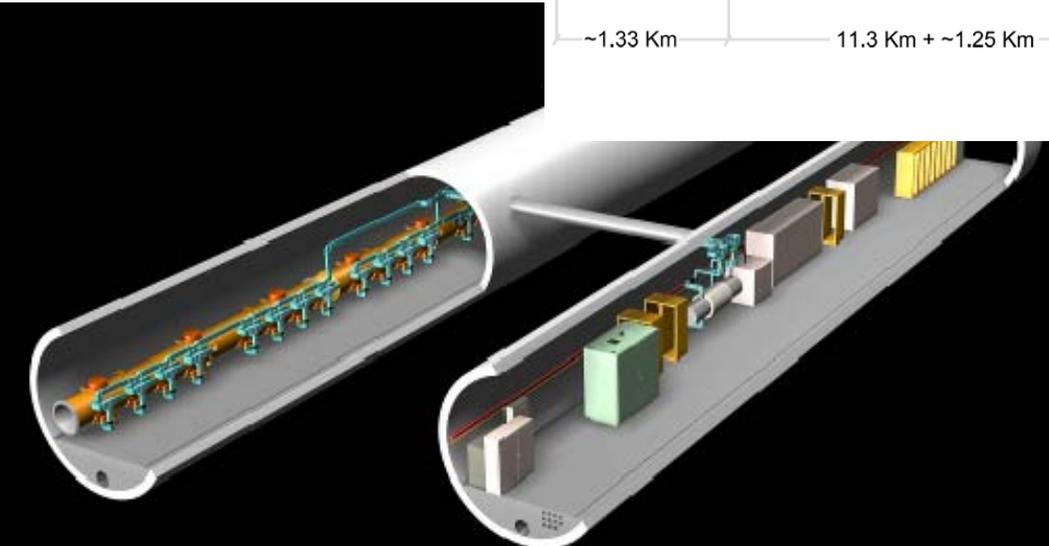
Gating(simulation)

Brief review of ILC 1st Stage: 500 GeV

Total ~31 km at 1st stage 500GeV CM energy
 Single dumping ring @center



Schematic Layout of the 500 GeV Machine



Two tunnels for Linac

9-cell cavities will provide 31.5MV/m

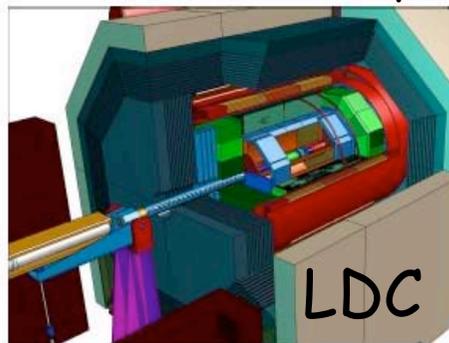
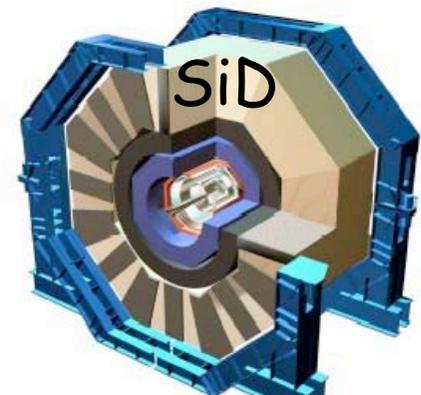
Expected Cost



4.87 B\$

1.78 B\$ site specific

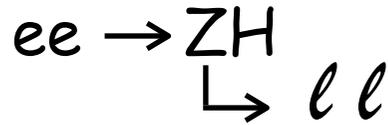
Detector Concept



TPC is a main tracker for GLD/LDC

Requirements from ILC

LC TPC has to provide
good momentum resolution
(high mom. tracks

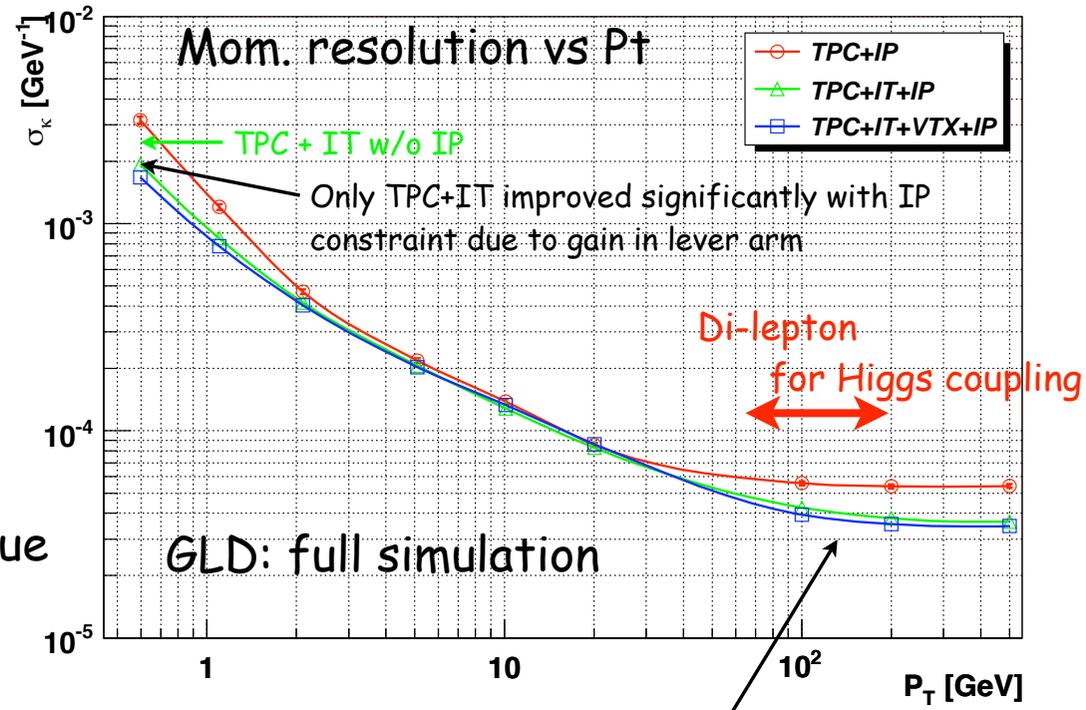
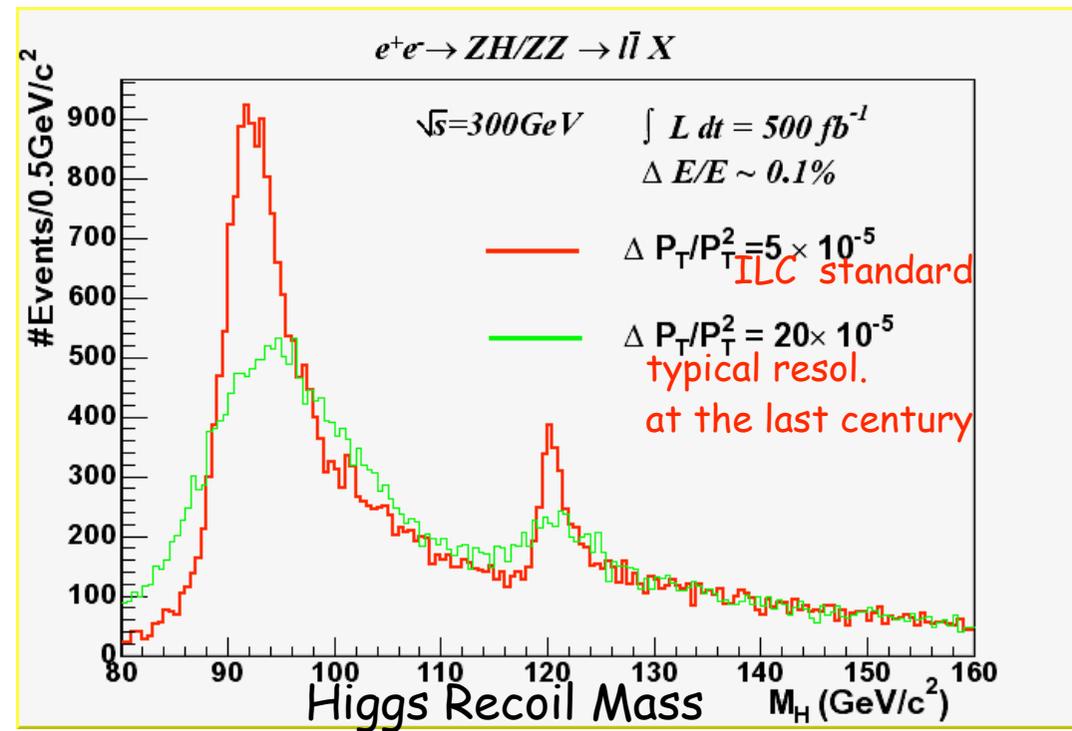


for Higgs coupling measurement

Expected momentum resolution
can be obtained
with 150um (GLD : 100um for LDC)
local position resolution
for TPC
together with IT + VXD

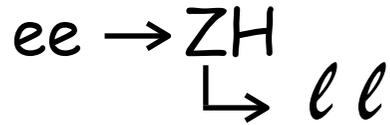
How can we get 100/150um resolution
even for 2m drift

Tracking efficiency is another important issue
for Jet Energy resolution
(ie. Particle Flow Algorithm)



Requirements from ILC

LC TPC has to provide
good momentum resolution
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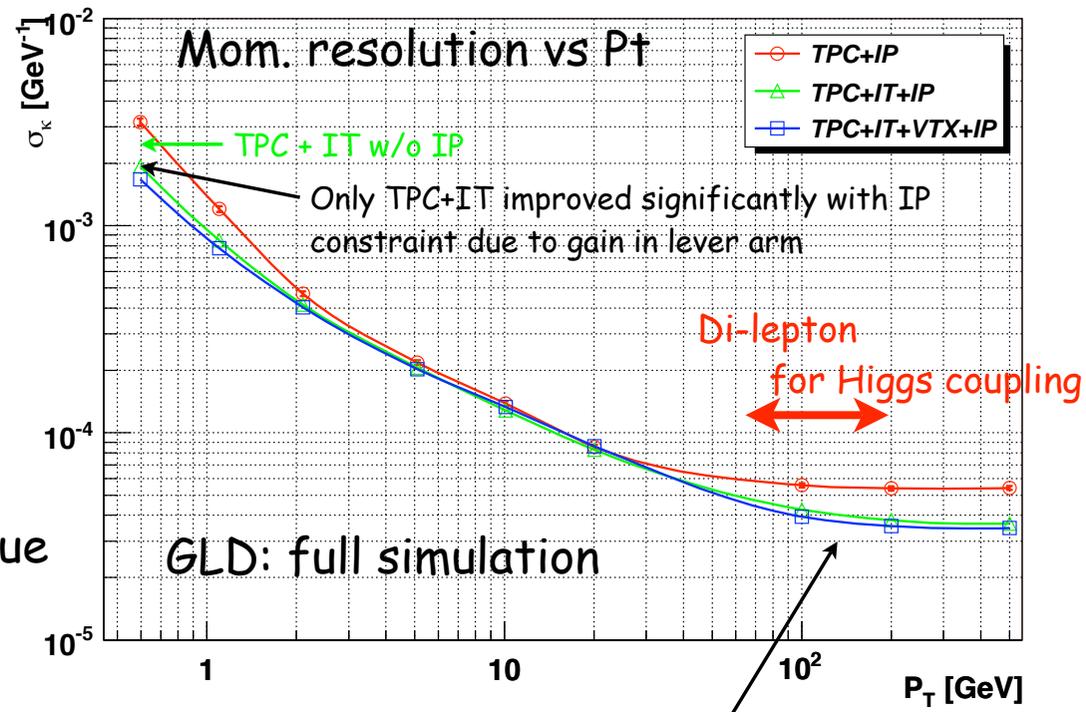
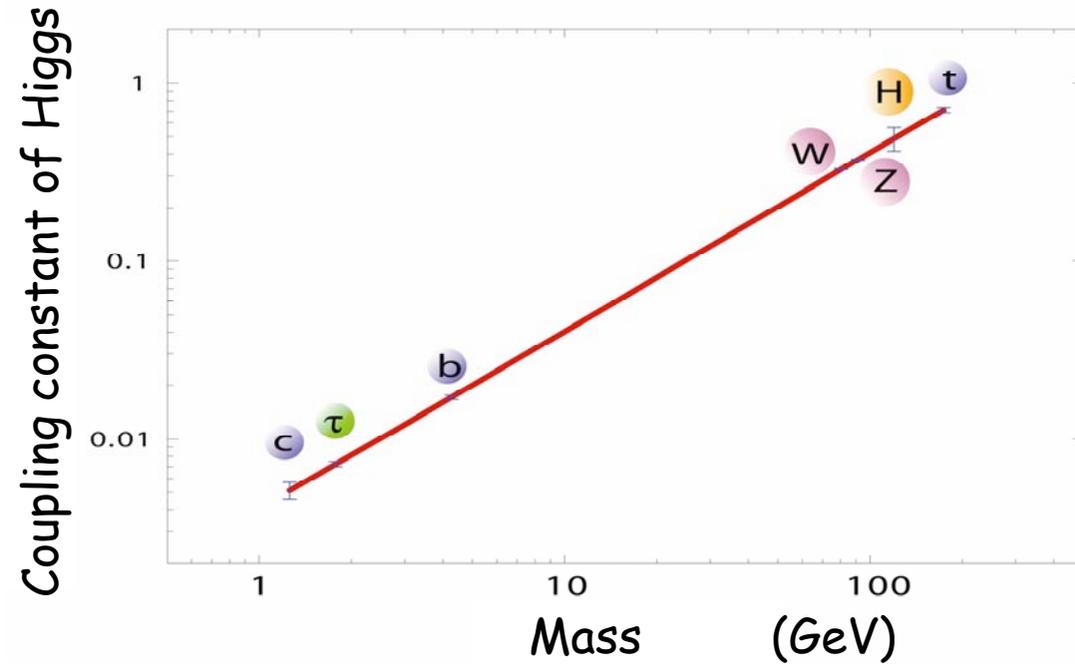
for Higgs coupling measurement

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How can we get 100/150um resolution
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for Jet Energy resolution
(ie. Particle Flow Algorithm)

Coupling-Mass Relation

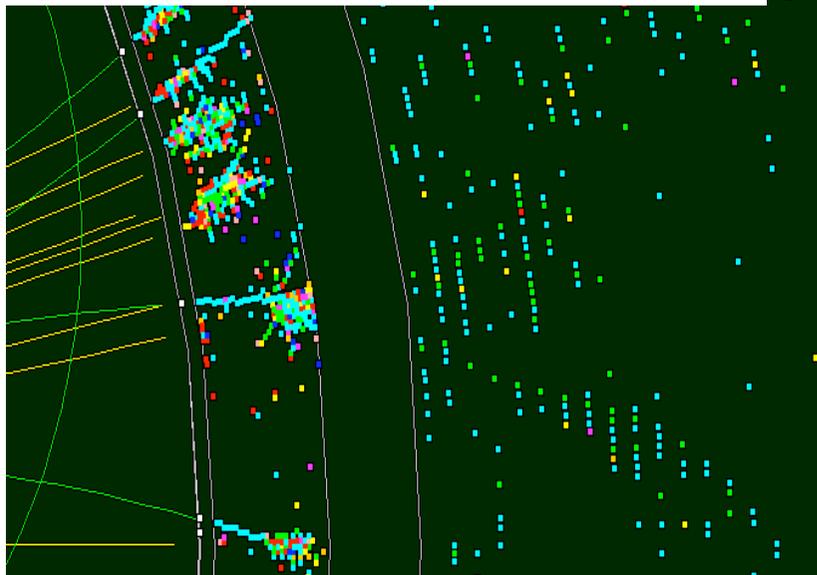
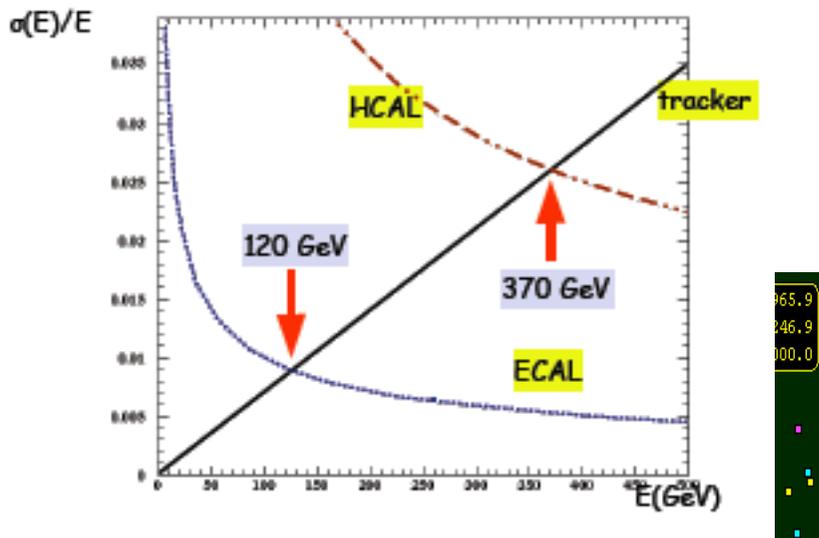


Jet energy resolution using PFA(Particle Flow Algorithm)

$dE/E \sim 30\%$

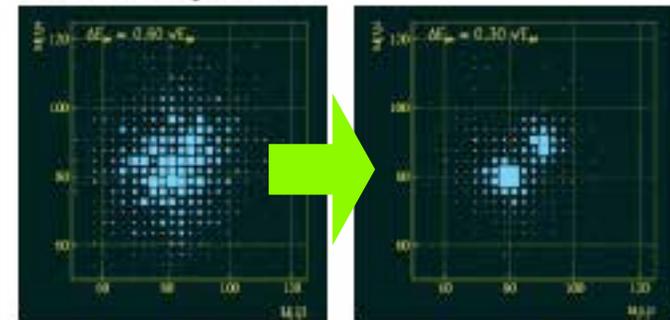
discrimination of Z/W

Resolution tracker - Calorimeter



WW-ZZ separation

$M_{J_3J_4}$



$M_{J_1J_2}$

HCAL dominate a resolution

Tracker must provide high efficiency
(powerful pattern recognition capability)

rather than high mom. resolution
@ 1 TeV ILC

Detection efficiency

robust tracking
2 track separation
boundary effect

Background @ ILC

mini-jets

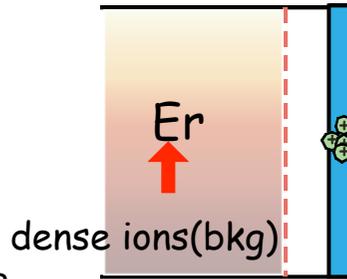
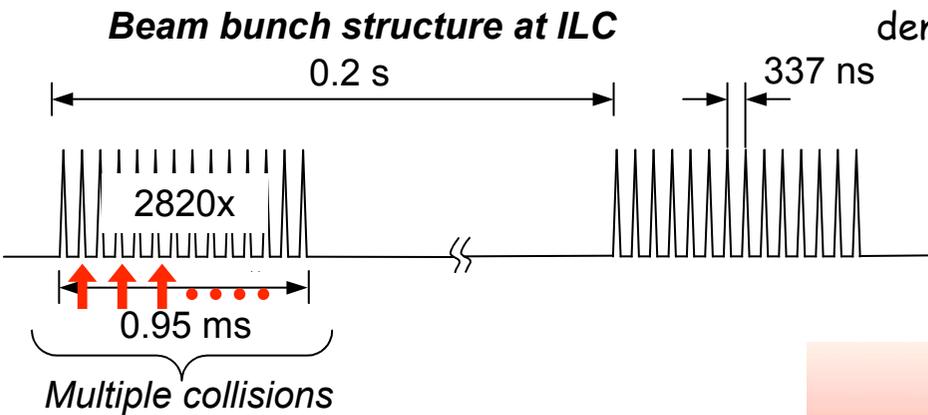
2×10^4 tracks/train ~ 10 tracks/bunch
 $\sim O(0.3\%)$ occupancy @ innermost raw($r=45\text{cm}$)
naive estimation

low Pt tracks contribute more(curling)

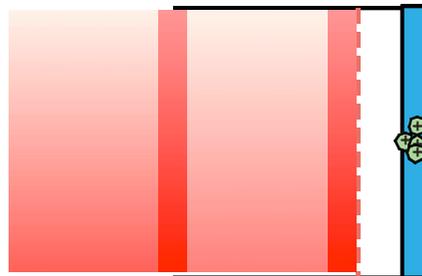
these rates are dep. on BDS/IR design

GAS in TPC (H less gas ?)

Beam Structure @ ILC



train produce back-drift ions' disk
 without "Gate mechanism" for ions



MPGD has a natural ability of gating ions, but it's not perfect.

We need "GATE"ing GRID

Physics background

2 photon process - mini jets

Beam background

pair background

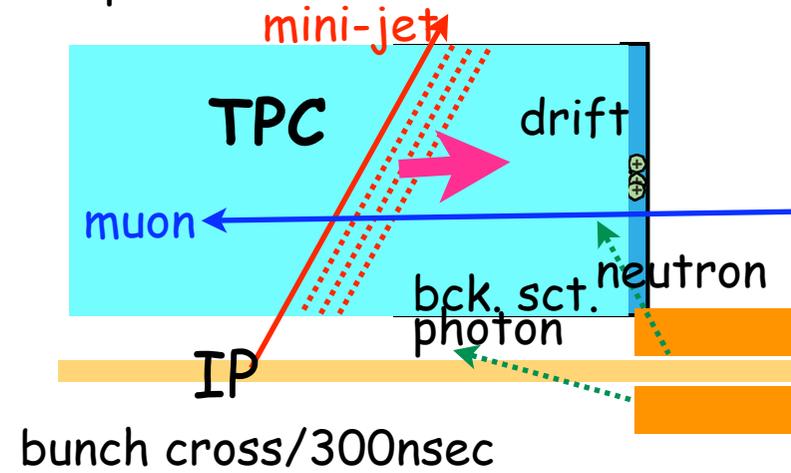
disrupted beam

beam dump

photon, electrons

muon

neutron



Concept of ILC-TPC

good position resolution
~ 100 μm

good trk. efficiency

under realistic bkg. condition &
non-uniform field

high B field

Lorentz angle
reduce diffusion effect

maximize hit information
no dead space on endplate

low material budget

MPGD sensor TPC

with Gate mechanism

micro structure
reduce ExB effect

direct signal
fine readout

MWPC : too large ExB effect

How to achieve 100um resolution

naive expectation of local resolution

$$\sigma_r = \sqrt{\sigma_0^2 + \frac{C_D^2 \cdot z}{N}}$$

this term dominate @ long drift

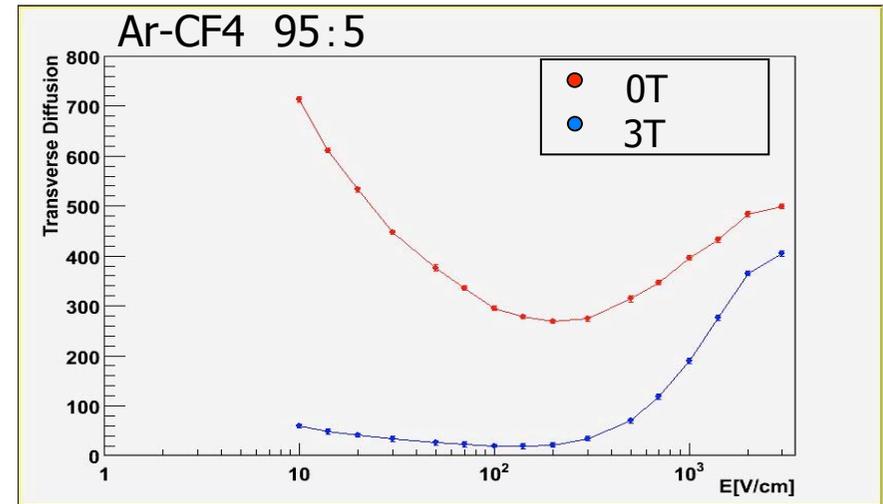
low diffusion gas @ B field

uncertainty @ MPGD

How really resolution behave ?

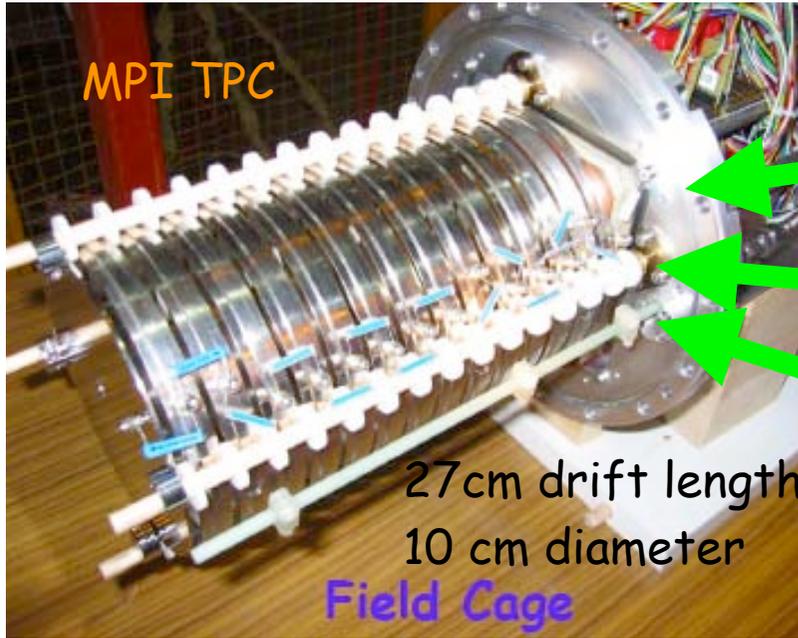
Issues of **Small Prototype test**

Clarify σ_0 and C_D and N



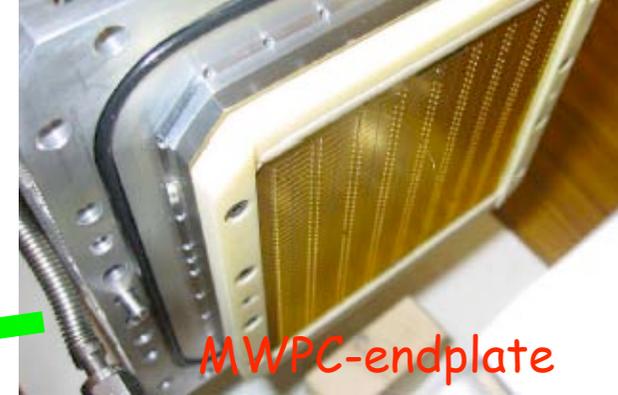
Small Prototype test

Series of prototype TPC tests in Japan



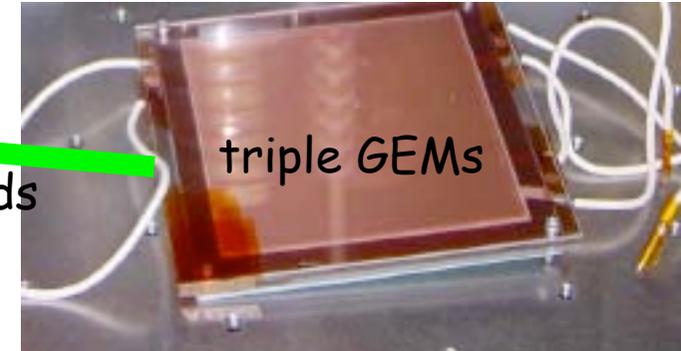
MWPC-TPC

2.3x6.3 mm² pads
TDR gas



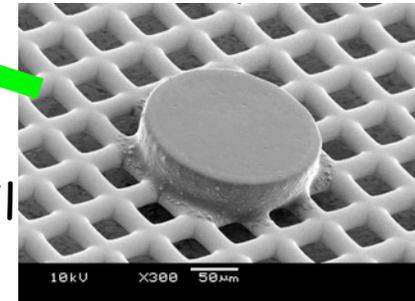
GEM-TPC

1.27x6.3 mm² pads
TDR, P5 gas



Micromegas-TPC

2.3x6.3 mm² pads
w/,w/o resistive foil
Ar+isoC₄H₁₀ gas



measurement of diffusion(gas property)

$$\sigma_{SS} = \sqrt{\sigma_{PR}^2 + C_D^2 Z}$$

resolution $\sigma = \sqrt{\sigma_0^2 + \frac{C_D^2 Z}{N_{eff}}}$

diffusion plot (z dependence)

$$\sigma_{PR}^2 = \sigma_{PR0}^2 + C_d^2 \cdot z$$

TDR gas

$$C_d = 213.0 \pm 0.4 \mu\text{m}/\sqrt{\text{cm}}$$

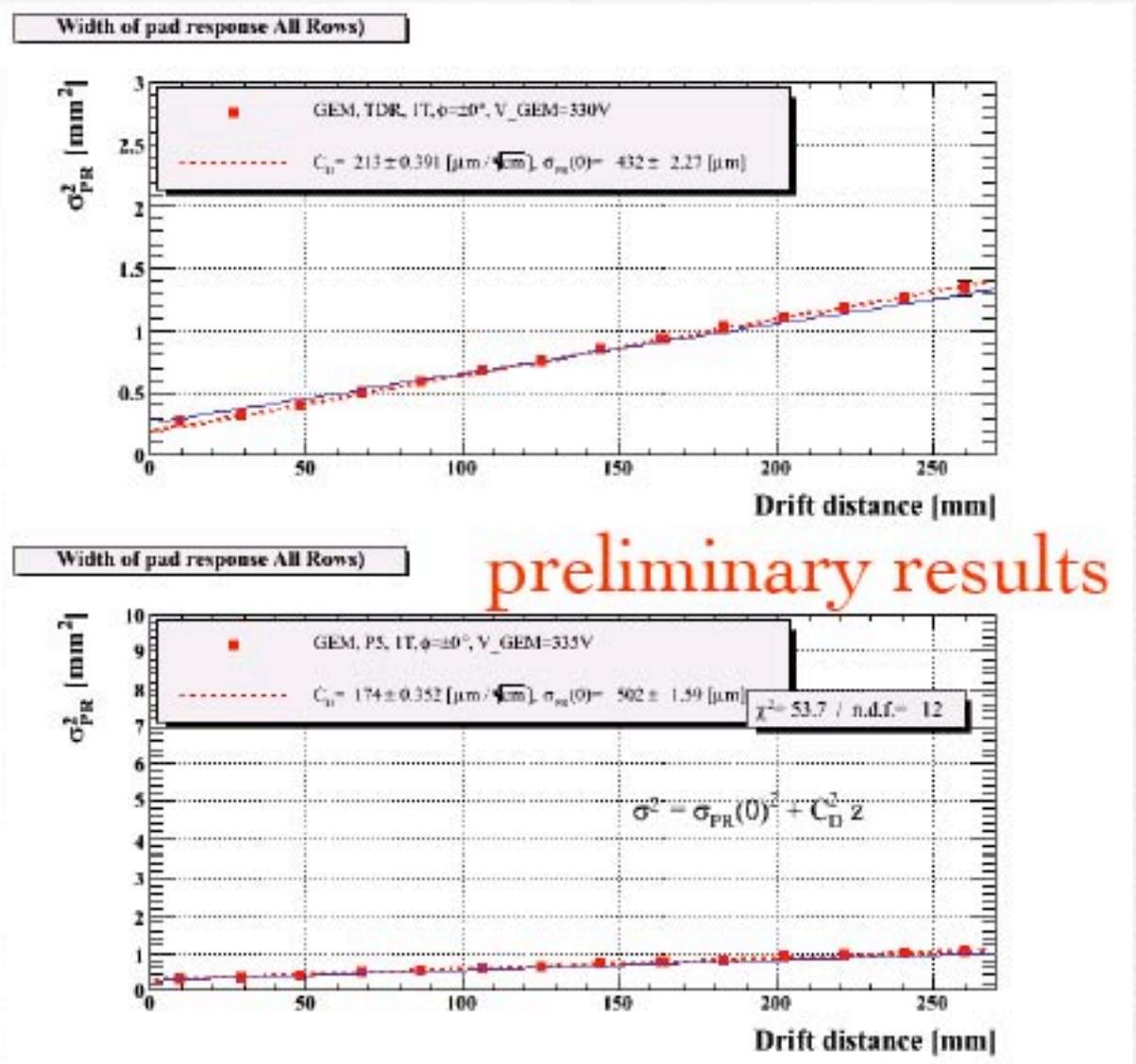
$$= 200 \mu\text{m}/\sqrt{\text{cm}}$$

P5

$$C_d = 174.0 \pm 0.4 \mu\text{m}/\sqrt{\text{cm}}$$

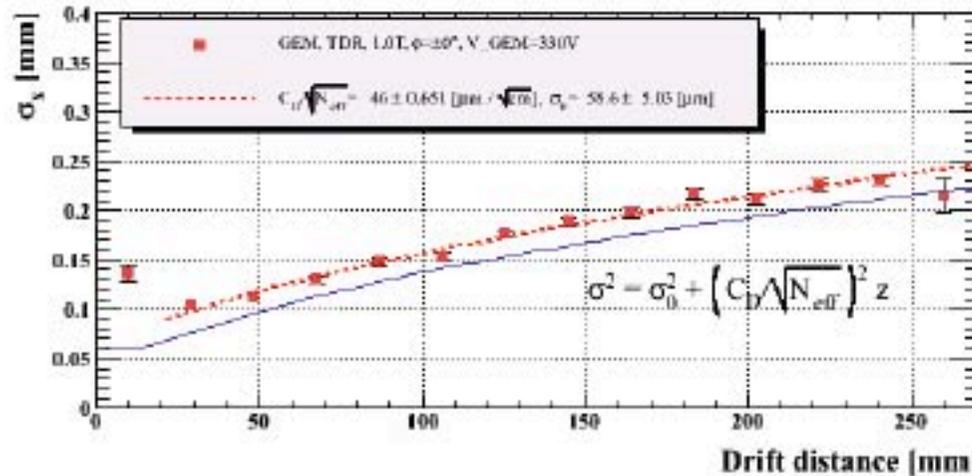
$$= 166 \mu\text{m}/\sqrt{\text{cm}}$$

well understood by magboltz



x resolution (z dependence)

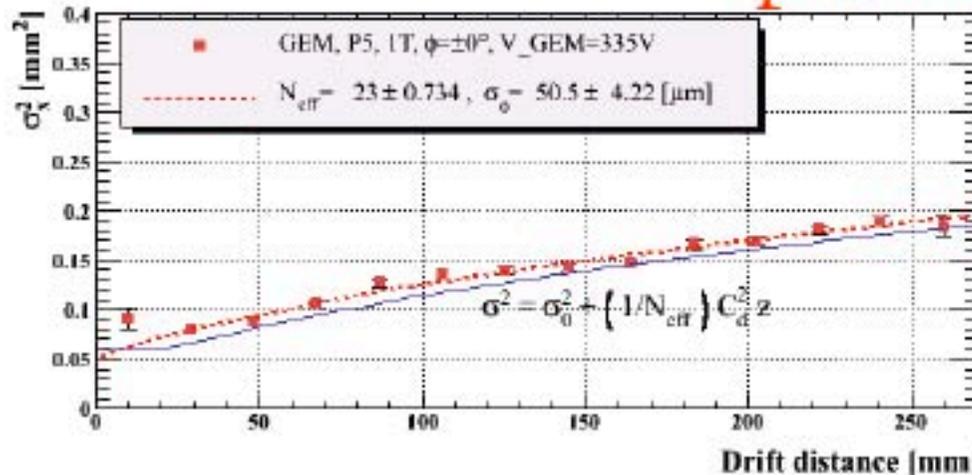
TDR gas



$$\sqrt{\sigma_0^2 + \frac{C_D^2 z}{N_{\text{eff}}}}$$

$$N_{\text{eff}} = 21.4 \pm 0.3$$

P5



preliminary results

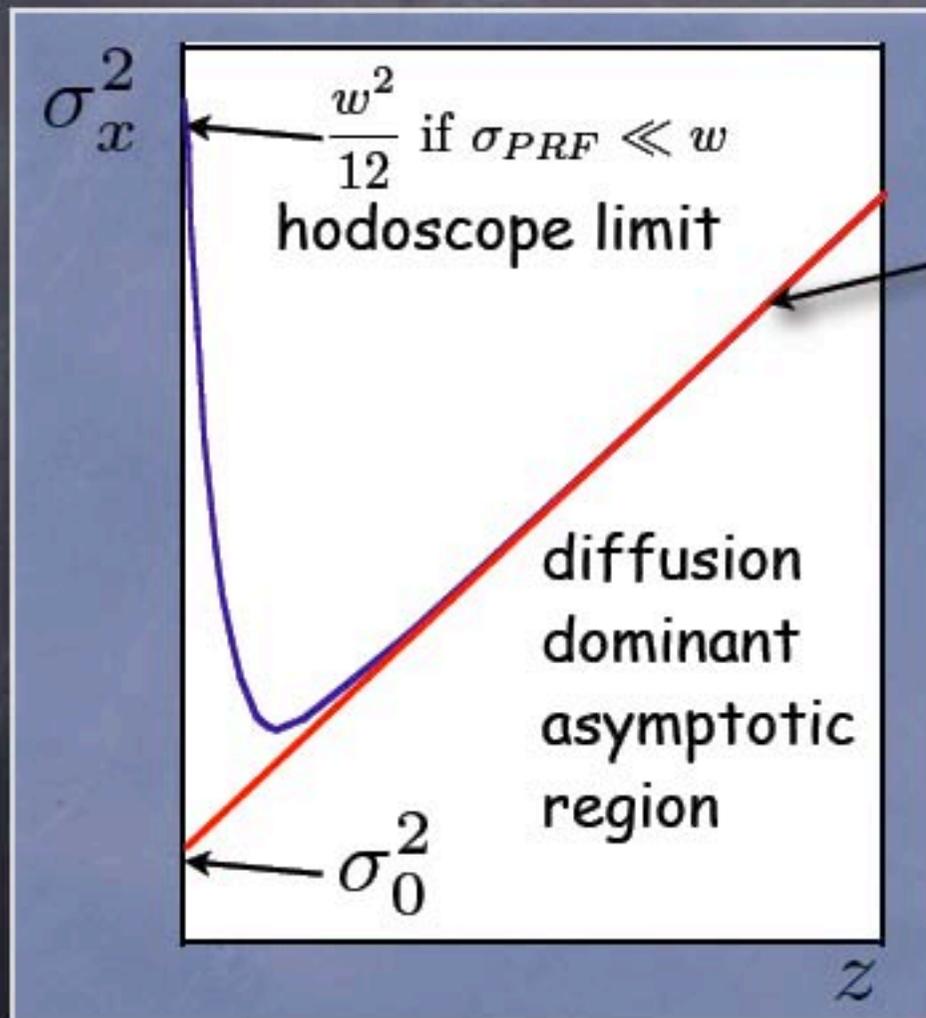
$$N_{\text{eff}} = 23.0 \pm 0.7$$

$$= 22$$

Pad length $\sim 6\text{mm}$: we expect $N \sim 60$ but it was ~ 20

Two Mysteries

Generic behaviors of resolution with an MPGD endplate when the lateral avalanche spread is much smaller than the pad width



$$\sigma_x^2 = \sigma_0^2 + C_d^2 z / N_{eff}$$

- Why $N_{eff} < \langle N \rangle$?
- What is the origin of $\sigma_0 \equiv \sigma_x(z = 0)$?

It's there even if electronic noise is negligible!

Ionization Statistics

Ideal Readout Plane: Coordinate = Simple C.O.G.

PDF for Center of gravity of N electrons

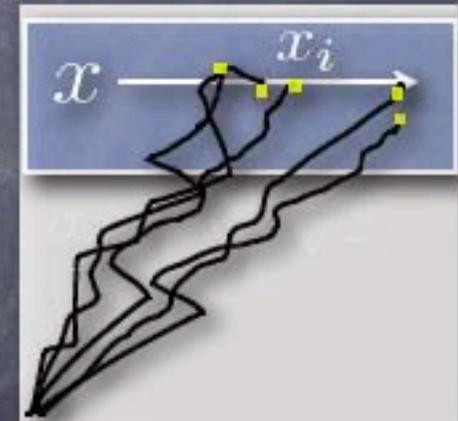
$$P(\bar{x}) = \sum_{N=1}^{\infty} P_I(N; \bar{N}) \prod_{i=1}^N \left(\int dx_i P_D(x_i; \sigma_d) \right) \delta \left(\bar{x} - \frac{1}{N} \sum_{i=1}^N x_i \right)$$

Ideal readout plane

Gaussian diffusion

$$P_D(x_i; \sigma_d) = \frac{1}{\sqrt{2\pi}\sigma_d} \exp\left(-\frac{x_i^2}{2\sigma_d^2}\right)$$

$$\sigma_d = C_d \sqrt{z}$$



$$\sigma_{\bar{x}}^2 \equiv \int d\bar{x} P(\bar{x}) \bar{x}^2 = \sigma_d^2 \langle \frac{1}{N} \rangle \equiv \sigma_d^2 \frac{1}{N_{eff}}$$

$$N_{eff} \equiv 1 / \langle 1/N \rangle < \langle N \rangle$$

Gas Gain Fluctuation

Coordinate = Gain-Weighted Mean

PDF for Gain-Weighted Mean of N electrons

$$P(\bar{x}) = \sum_{N=1}^{\infty} P_I(N; \bar{N}) \prod_{i=1}^N \left(\int dx_i P_D(x_i; \sigma_d) \int d(G_i/\bar{G}) P_G(G_i/\bar{G}; \theta) \right) \delta \left(\bar{x} - \frac{\sum_{i=1}^N G_i x_i}{\sum_{i=1}^N G_i} \right)$$

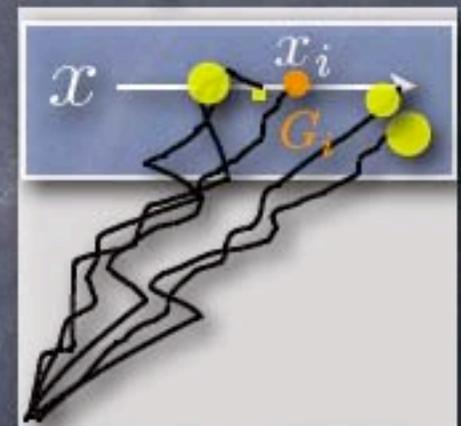
Gaussian diffusion as before

Gain-weighted mean

Gas gain fluctuation (Polya) $\theta = \begin{cases} 0 & : \text{exp.} \\ \infty & : \delta\text{-fun} \end{cases}$

$$P_G(G/\bar{G}; \theta) = \frac{(\theta + 1)^{\theta+1}}{\Gamma(\theta + 1)} \left(\frac{G}{\bar{G}} \right)^{\theta} \exp \left(-(\theta + 1) \left(\frac{G}{\bar{G}} \right) \right)$$

$$\sigma_{\bar{x}}^2 \equiv \int d\bar{x} P(\bar{x}) \bar{x}^2 = \sigma_d^2 \left\langle \frac{1}{N} \right\rangle \left\langle \left(\frac{G}{\bar{G}} \right)^2 \right\rangle \equiv \sigma_d^2 \frac{1}{N_{eff}}$$



$$N_{eff} = \left[\left\langle \frac{1}{N} \right\rangle \left\langle \left(\frac{G}{\bar{G}} \right)^2 \right\rangle \right]^{-1} = \frac{1}{\left\langle \frac{1}{N} \right\rangle} \left(\frac{1 + \theta}{2 + \theta} \right) < \langle N \rangle$$

Finite Size Pads

Coordinate = Charge Centroid

Charge on Pad j

$$Q_j = \sum_{i=1}^N G_i \cdot f_j(\tilde{x} + \Delta x_i) + \Delta Q'_j,$$

Electronic noise

$$\langle \Delta Q^2 \rangle = \sigma_E^2$$

track position

$$x_i = \tilde{x} + \Delta x_i$$

diffusion

$$\langle \Delta x^2 \rangle = \sigma_d^2 = C_d^2 z$$

Normalized response fun. for pad j

$$\sum_j f_j(\tilde{x} + \Delta x_i) = 1$$

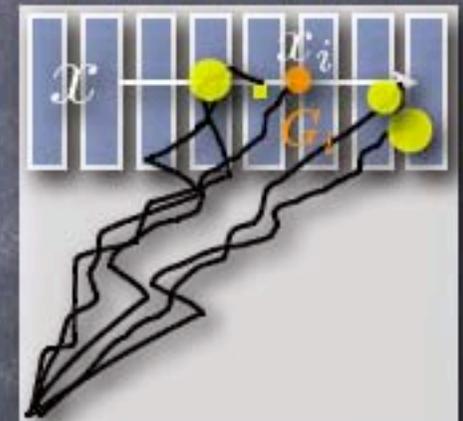
Charge Centroid

Pad pitch

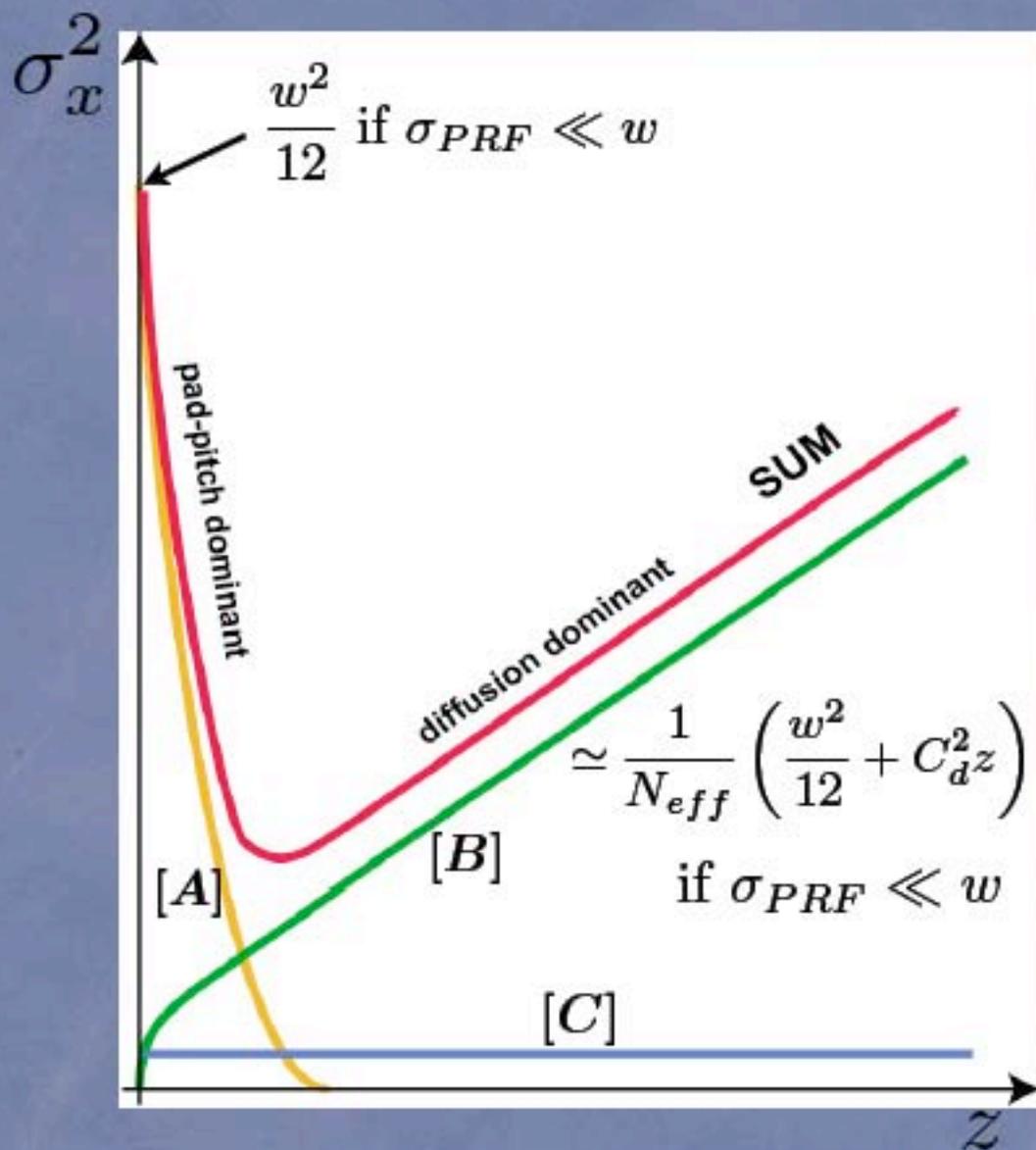
$$\bar{x} = \sum_j Q_j (w_j) / \sum_j Q_j$$

PDF for Charge Centroid

$$P(\bar{x}; \tilde{x}) = \sum_{N=1}^{\infty} P_I(N; \bar{N}) \prod_{i=1}^N \left(\int d\Delta x_i P_D(\Delta x_i; \sigma_d) \int d(G_i/\bar{G}) P_G(G_i/\bar{G}; \theta) \right) \\ \times \prod_j \left(\int d\Delta Q_j P_E(\Delta Q_j; \sigma_E) \int dQ_j \delta \left(Q_j - \sum_{i=1}^N G_i \cdot f_j(\tilde{x} + \Delta x_i) - \Delta Q_j \right) \right) \\ \times \delta \left(\bar{x} - \frac{\sum_j Q_j (w_j)}{\sum_j Q_j} \right)$$



Interpretation



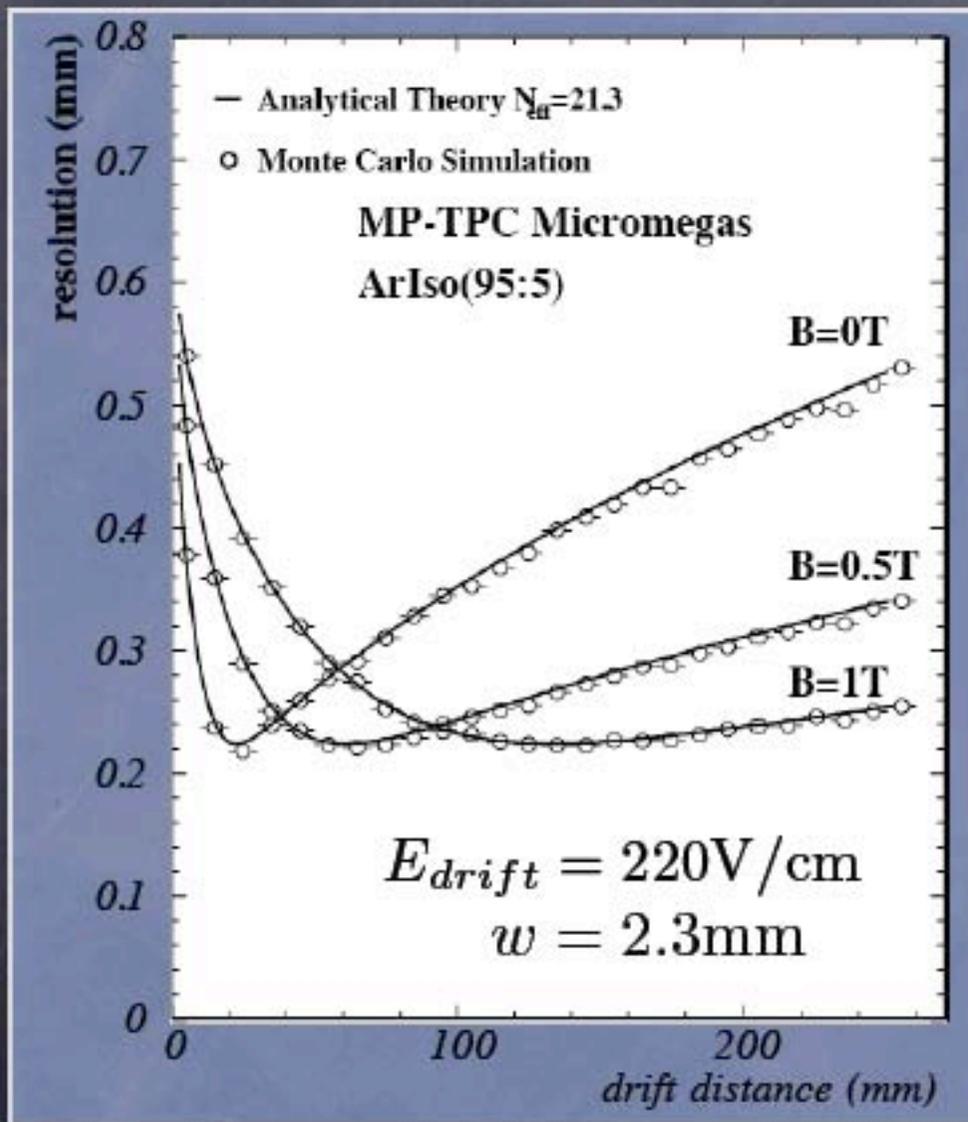
[A] Purely geometric term (S-shape systematics from finite pad pitch): rapidly disappears as Z increases

[B] Diffusion, gas gain fluctuation & finite pad pitch term: scales as $1/N_{eff}$, for delta-function like PRF asymptotically:

$$\sigma_x^2 \approx \frac{1}{N_{eff}} \left(\frac{w^2}{12} + C_d^2 z \right)$$

[C] Electronic noise term: Z -independent, scales as $\langle 1/N^2 \rangle$

Comparison with MC



- Theory reproduces the Monte Carlo simulation very well!
- We can estimate the resolution analytically

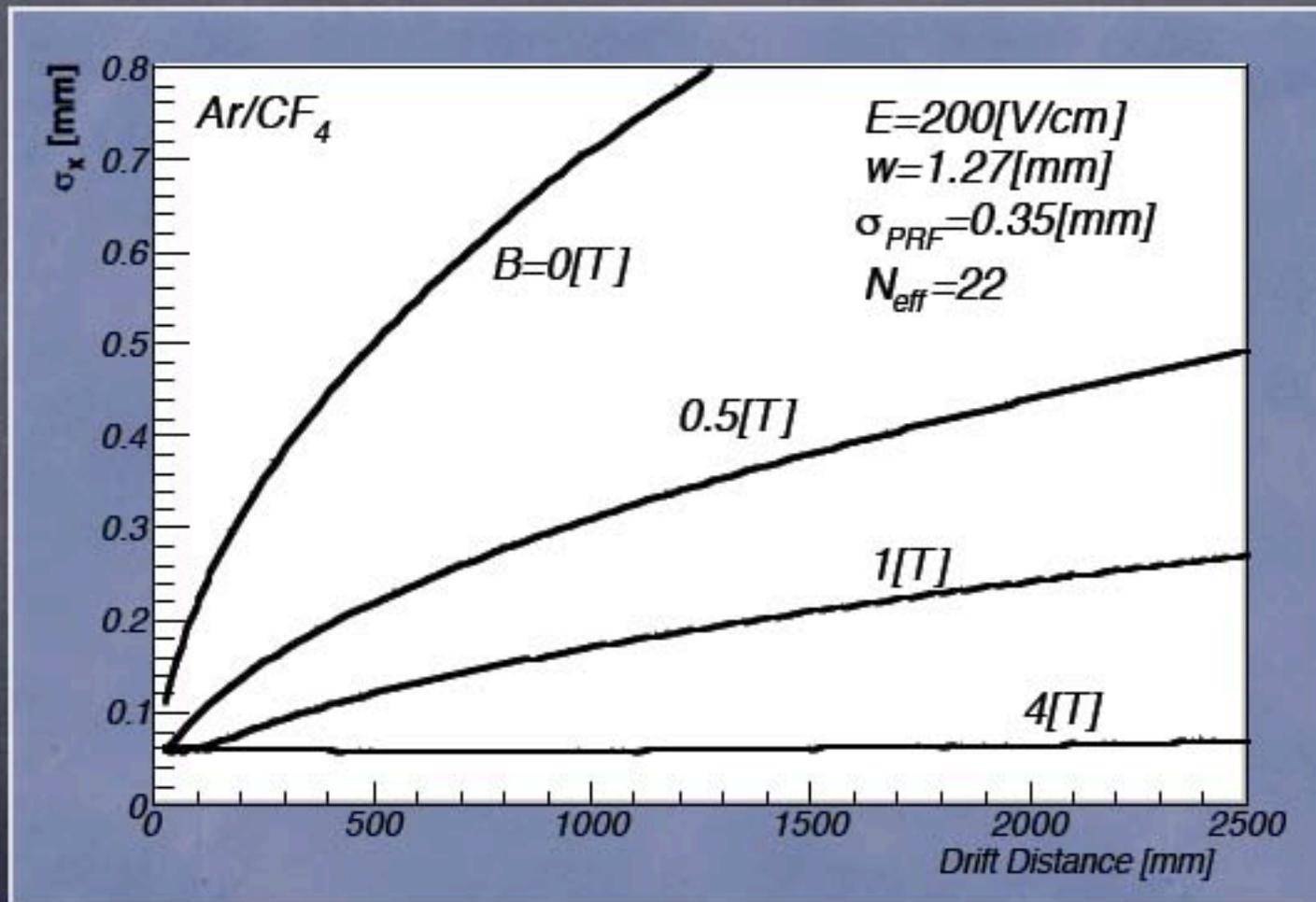
$$\sigma_x = \sigma_x(z; w, C_d, N_{eff}, [f_j])$$

drift distance
 pad pitch
 diffusion const.
 pad response function

δ -fun. for MM: $\sigma_{PRF} \simeq 12\mu m$
 gauss. for GEM: $\sigma_{PRF} \simeq 350\mu m$

Extrapolation to LC TPC

Sample calculation for GEM with Ar/CF₄



GEM in Ar/CF₄: promising but needs R&D

We may achieve required resolution in principle.

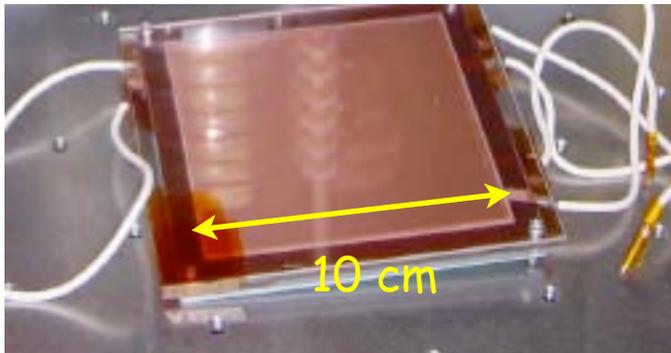
In order to avoid hod-scope effect

Diffusion @GEM must be larger than $0.3 \times \text{pad-pitch}$

Diffusion @ $E \sim 2-3 \text{ kV/cm}$ transfer + induction gap \longleftrightarrow pad pitch $\sim 1 \text{ mm}$

How do we achieve performance under realistic condition

Small Prototype



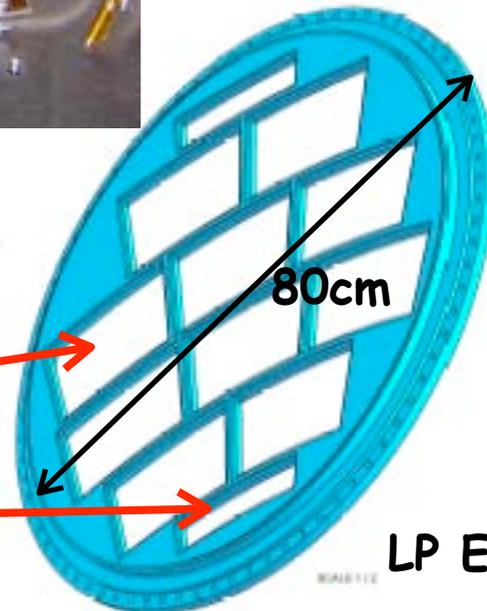
consideration of realistic GEM panel
How to reduce dead region

LargePrototype(LP1)

Size of panel
Panel boundary
mounting method of GEM
Gate

GEM/MM panel

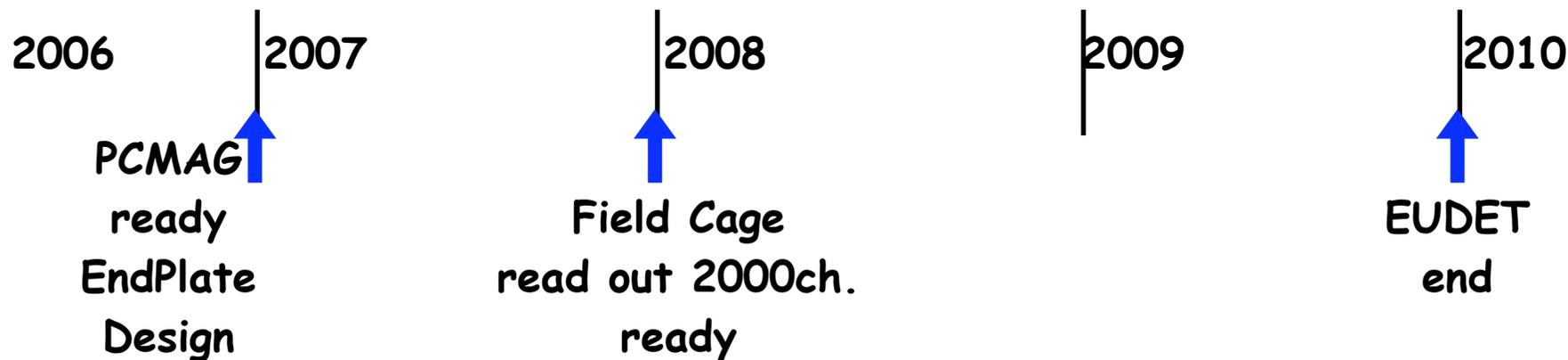
for Pixel



LP Endplate

LC-TPC prototype study schedule

EUDET



LargeProto 1

beam test ready

LargeProto 2

realistic electronics
realistic config.

Target date
of LP1

production

limited time for R&D !!

"Pre-PROTOTYPE"

though many issues are not fixed yet

What we want to do at Pre-prototype

Production of GEM panel

minimize dead area due to GEM support frame

specially in radial direction

we hope to remove radial frame

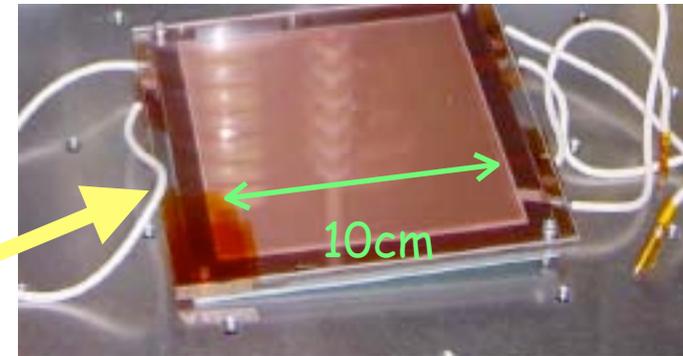
to avoid loss of series of hit info.

can we mount GEM properly ?

how do we stretch GEM?

we have competitor in LC-TPC group: team of Micromegas

who have experience to build large size detector for T2K



GEM we used

@Small prototype test

Readout Pad plane

GEM structure on the pad plane

mount structure to EP

Pad size

arrangement

readout connector

support structure of GEM

HV supply

Larger area GEM

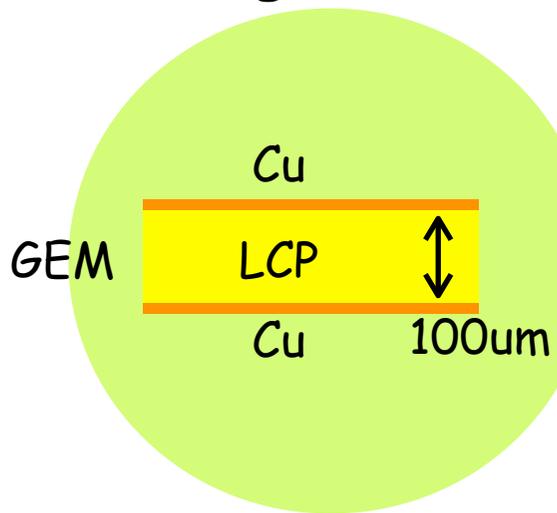
Gating structure

scheme

-> Dan Petersen

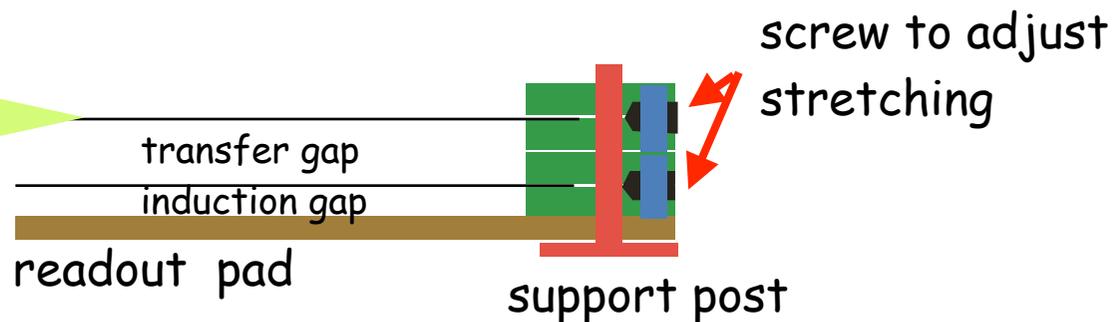
common system in LP

Conceptual design



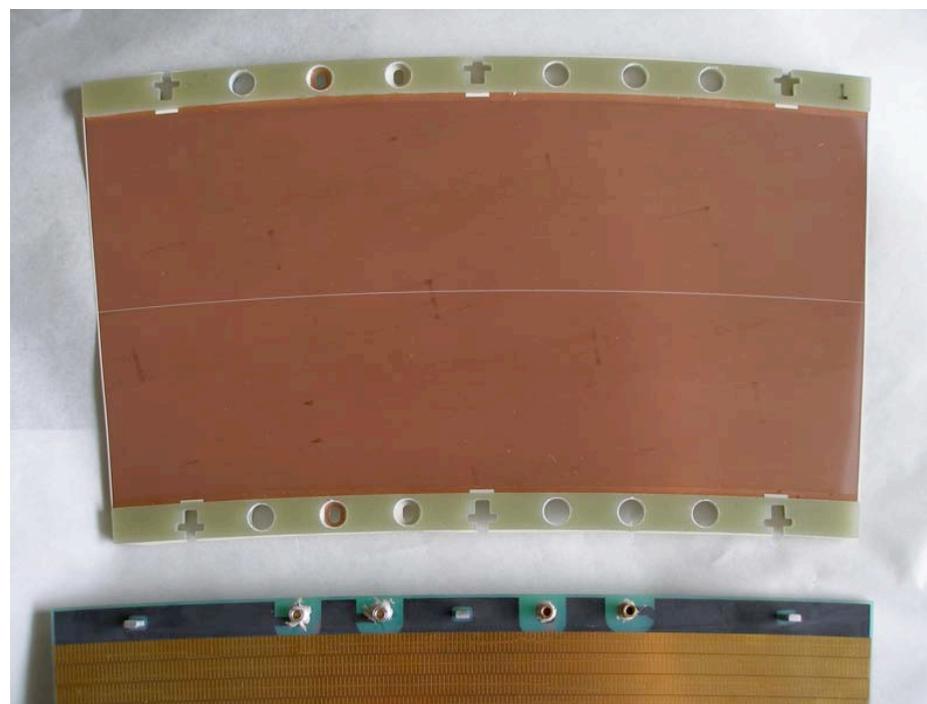
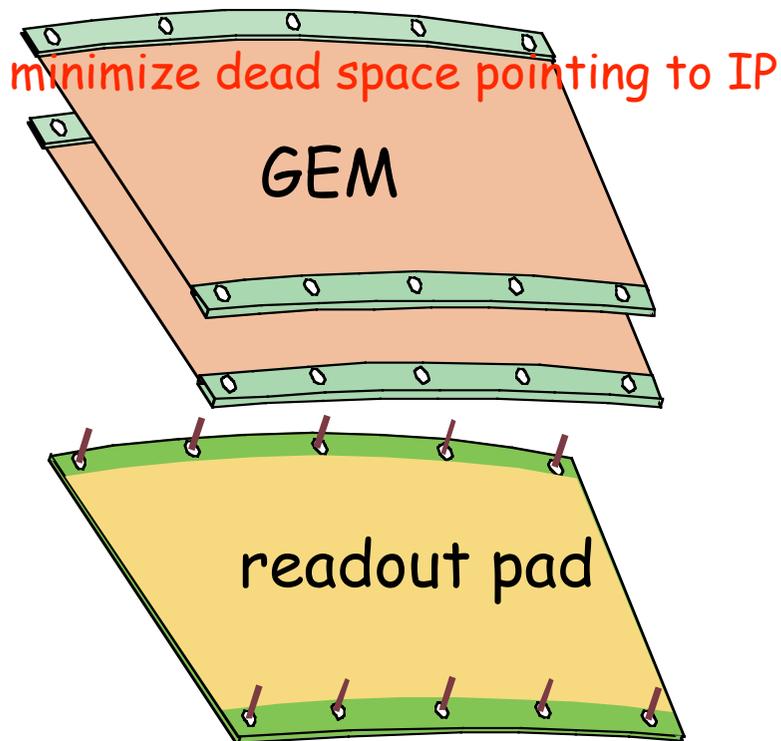
Can we stretch GEM ?

mounting(stretch) mechanism

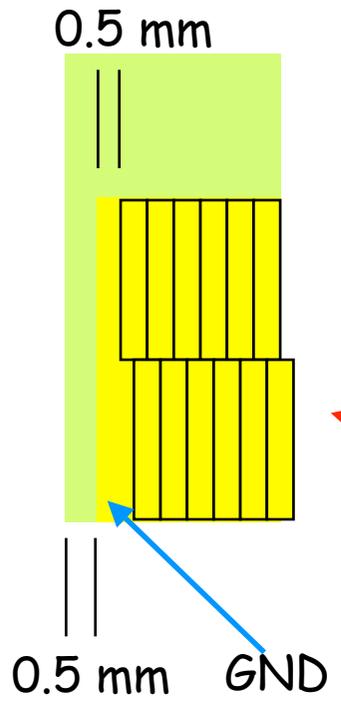


frame : top & bottom frame.
no side frame

Transfer gap ~ 4mm : enlarge signal distribution
(+2mm) width > 0.3* pad pitch

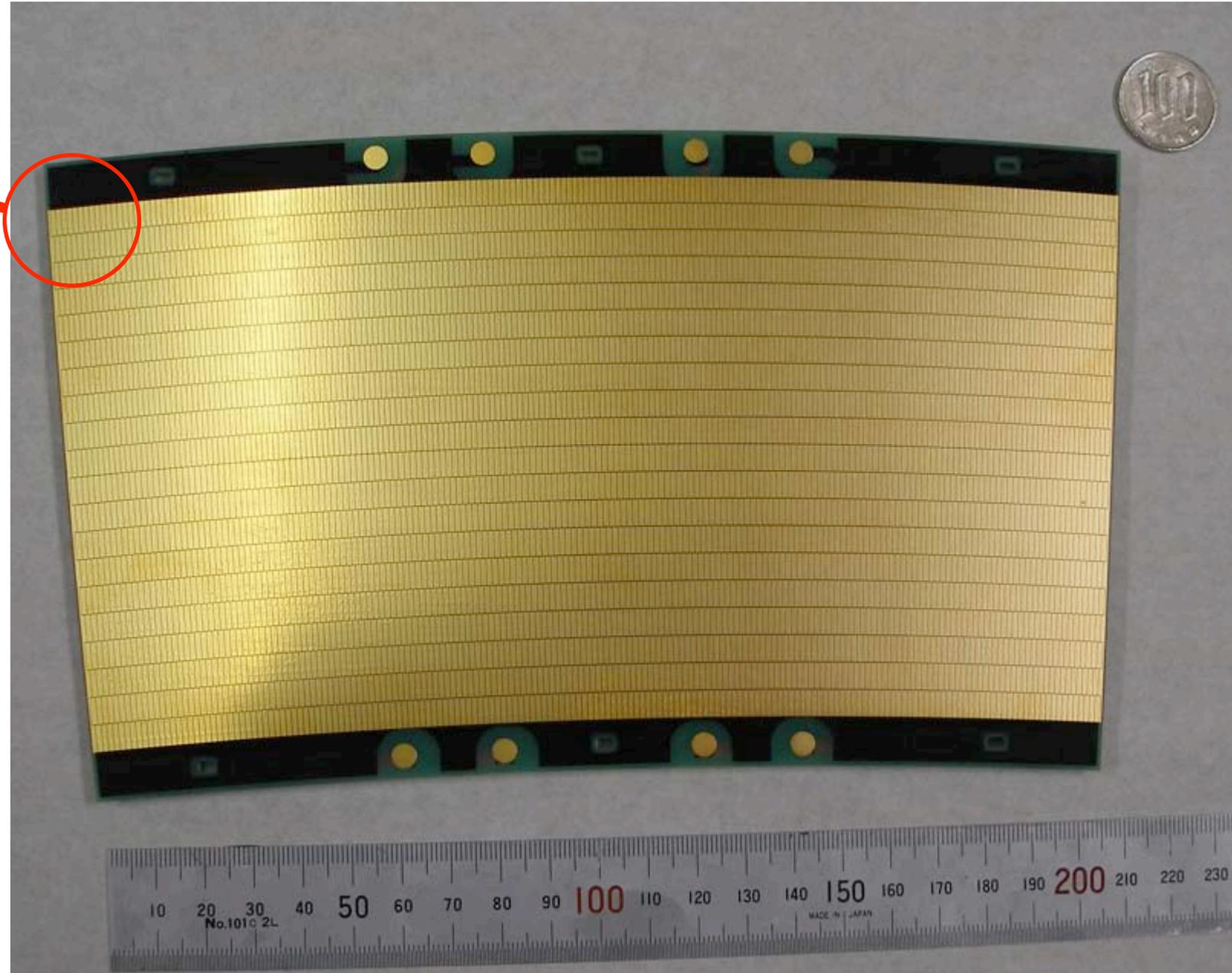


Pad plane

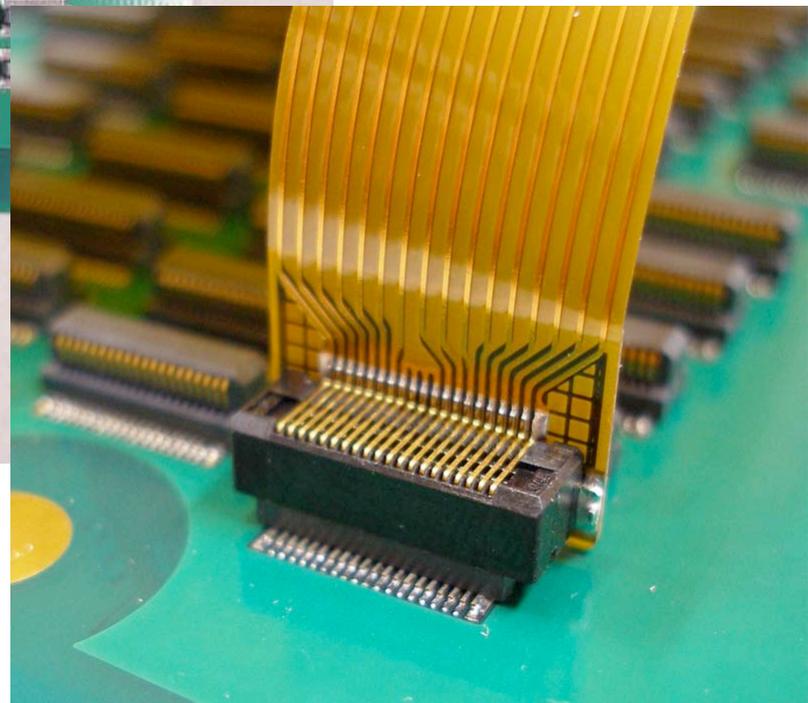
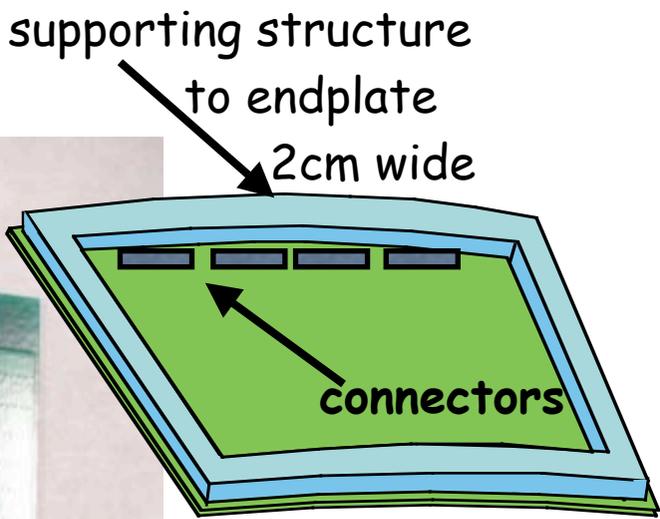
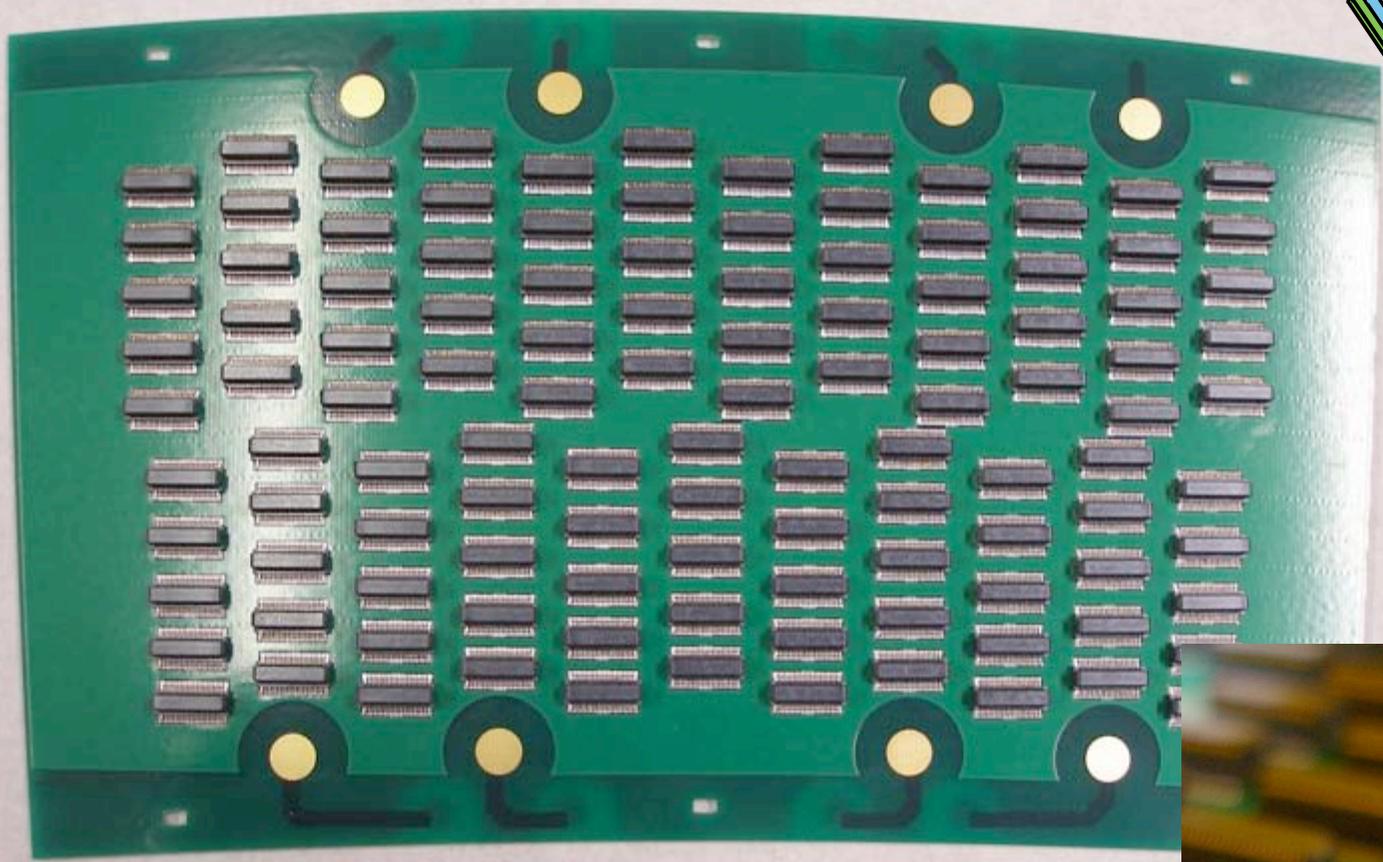


6 layered PCB

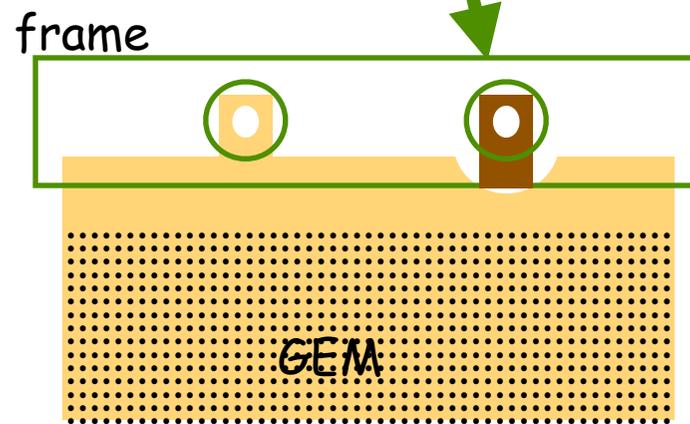
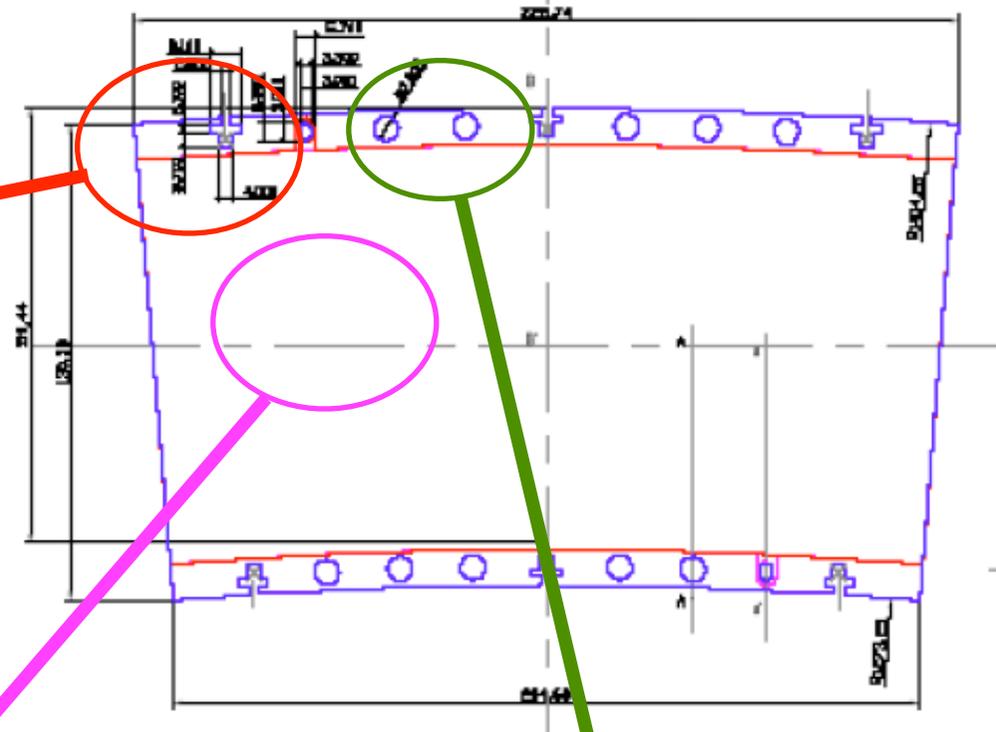
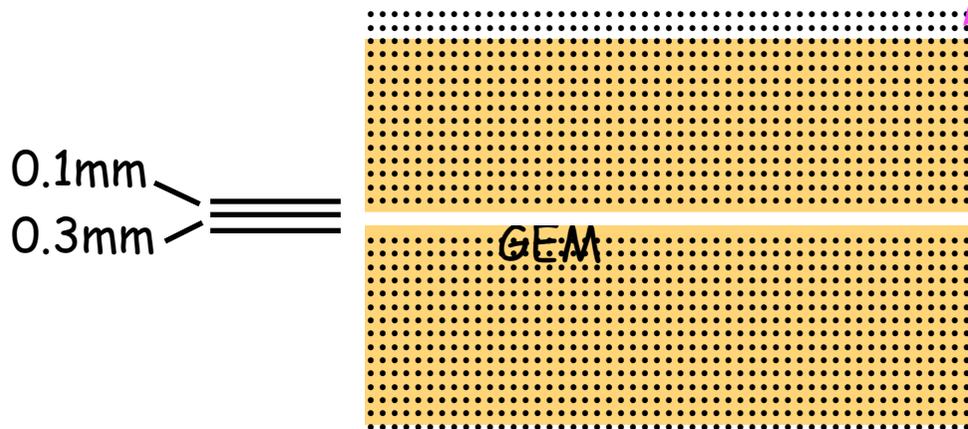
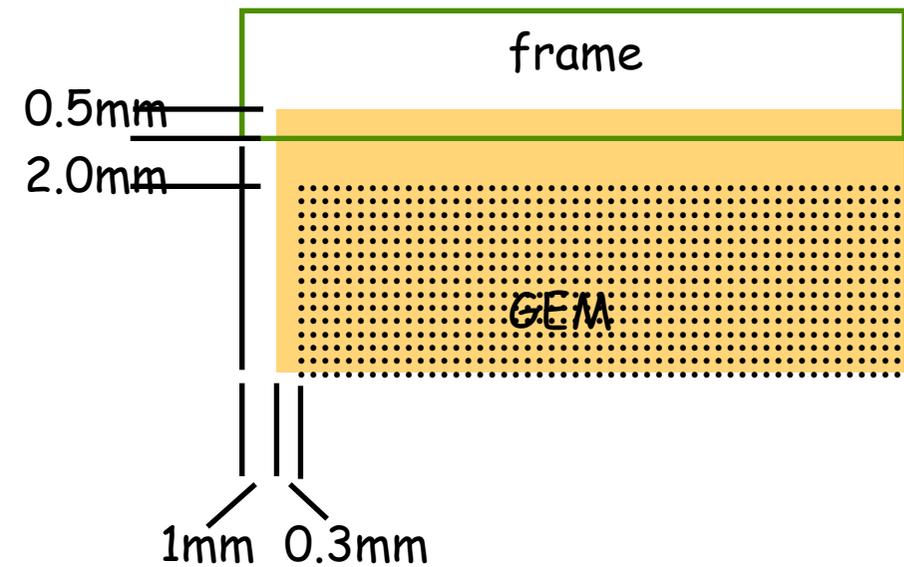
- Pad size ~ 1.1 x 5.6 mm
- 20 pad rows
- 192 pads (outer half row)
- 176 pads (inner half row)

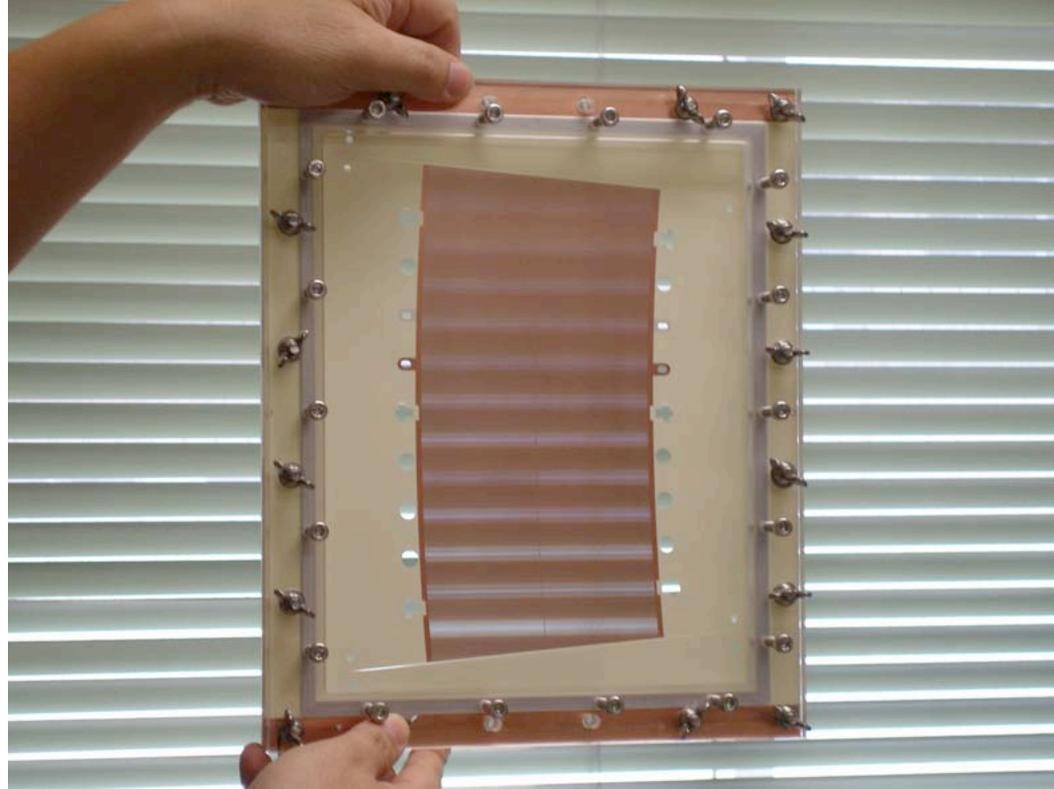
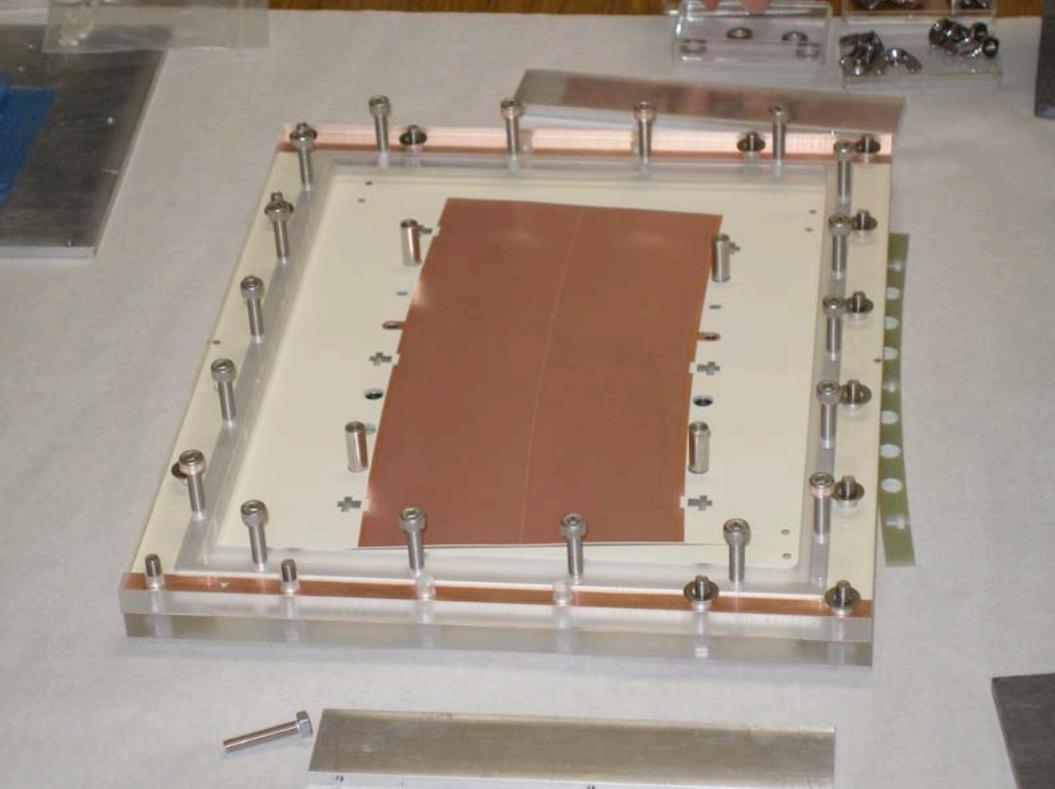
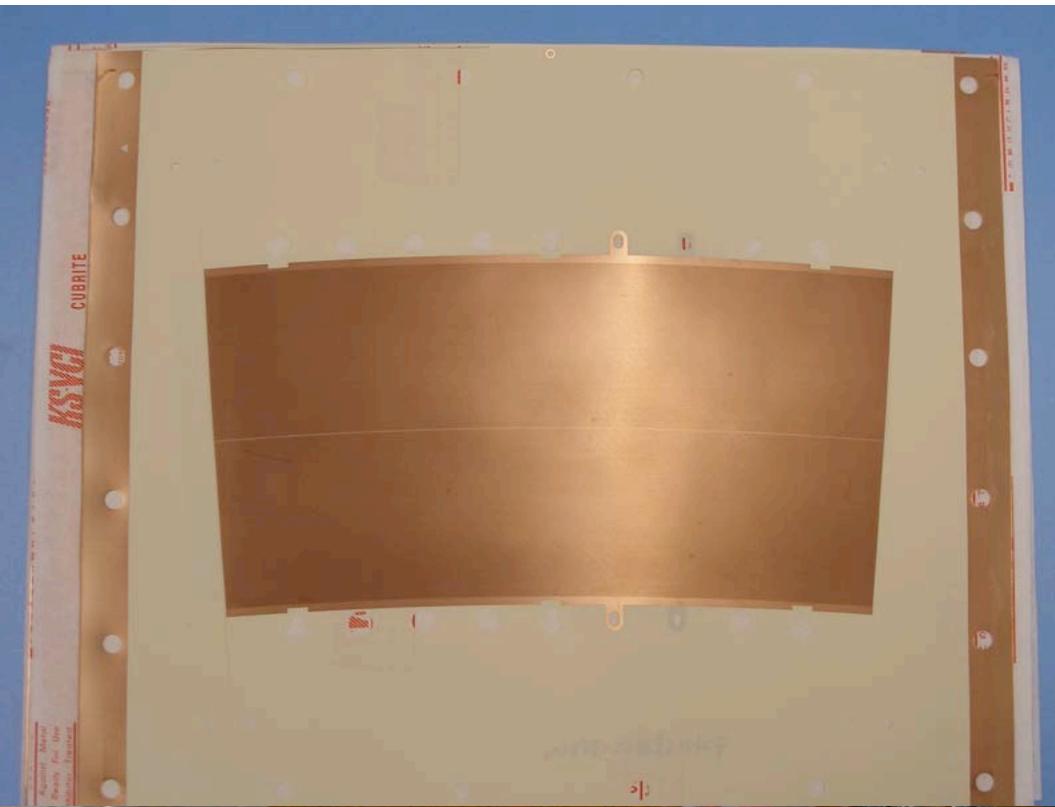


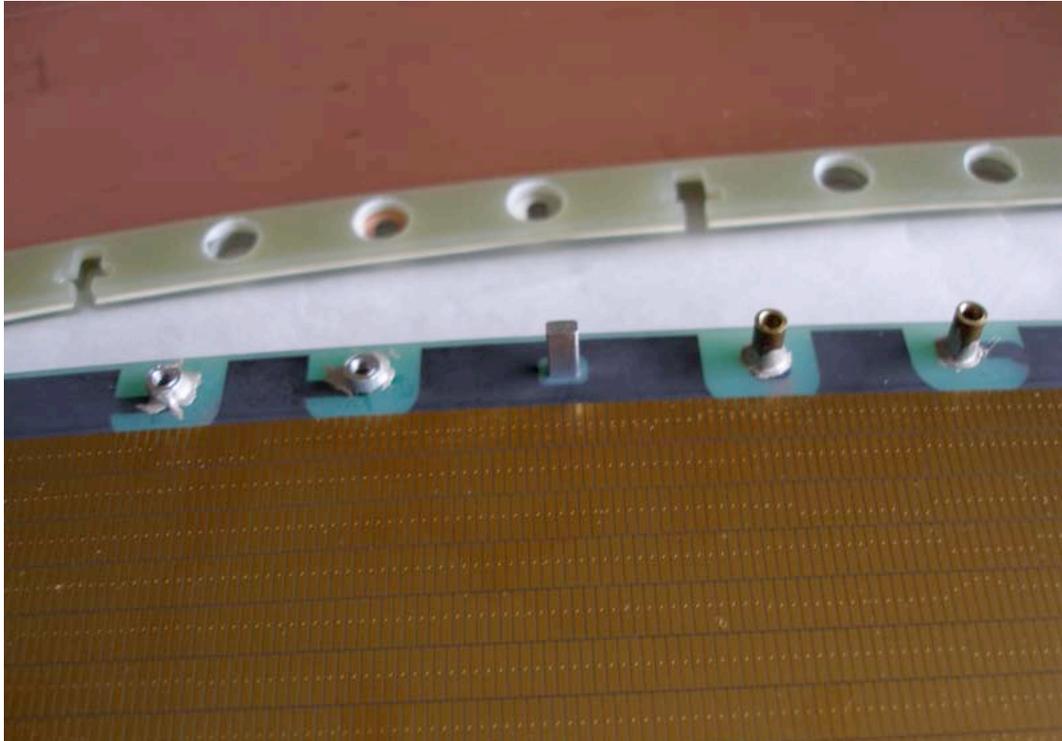
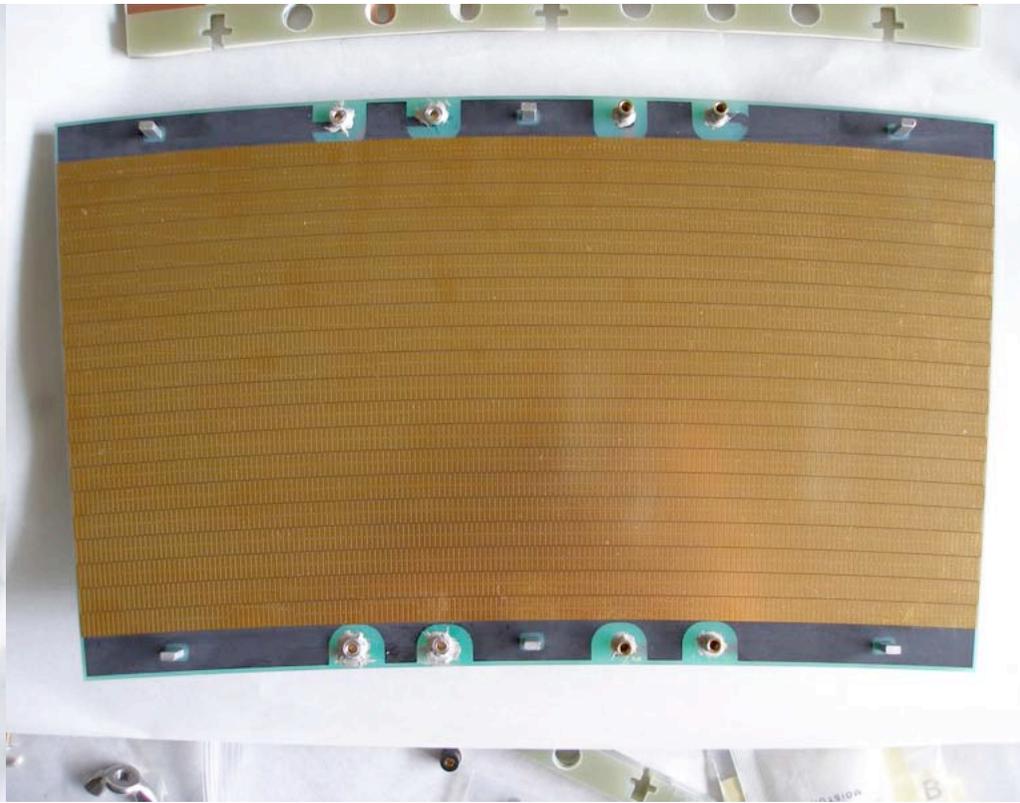
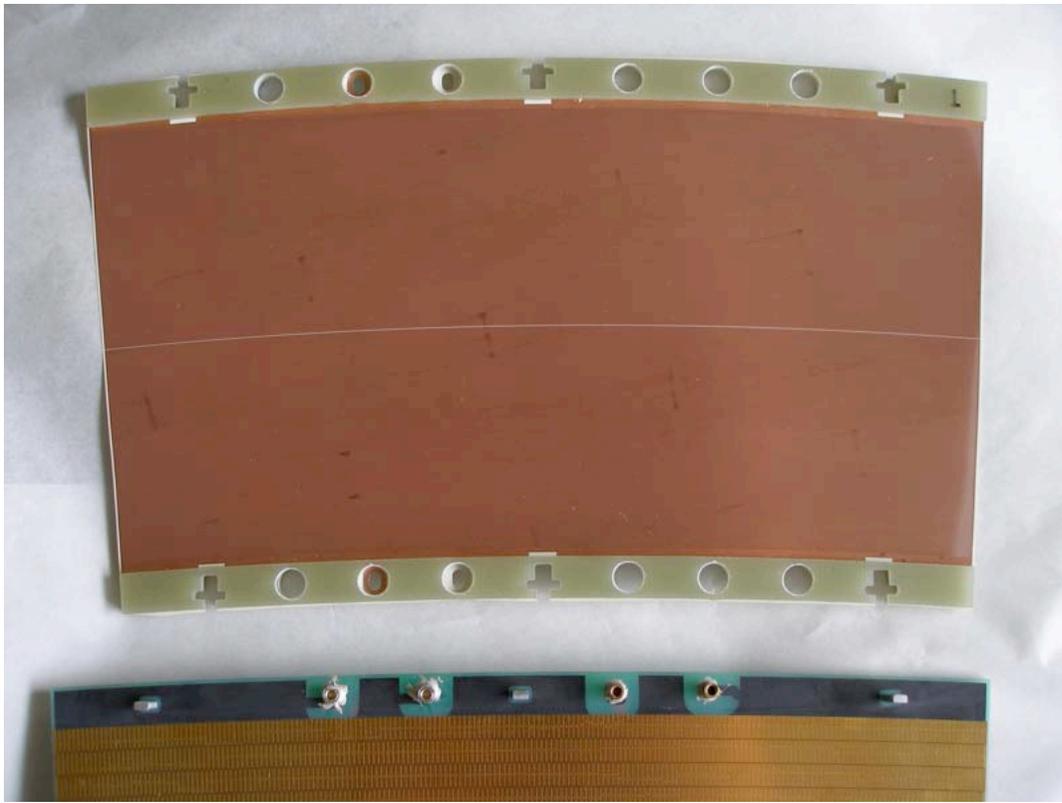
Pad plane - rear side



GEM







Plan of pre-prototype

gas container box will be ready soon.

check the mechanism of GEM mount under regular operation

gas gain uniformity over all panel by Fe source

long term stability

start design work for LP1(real prototype) GEM panel

start production LP1 panel from September

will be ready for beam test at the end of December

Gating for back-drift ions

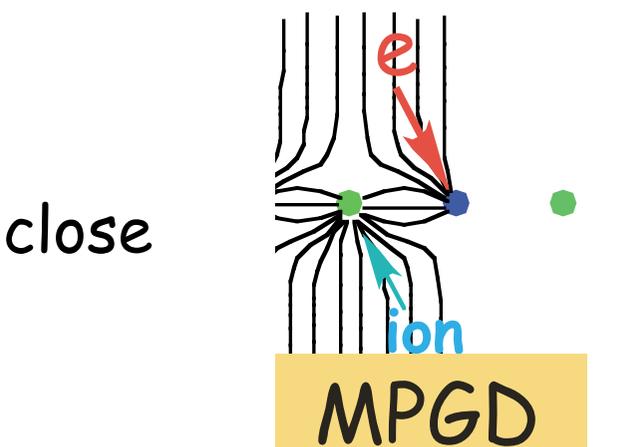
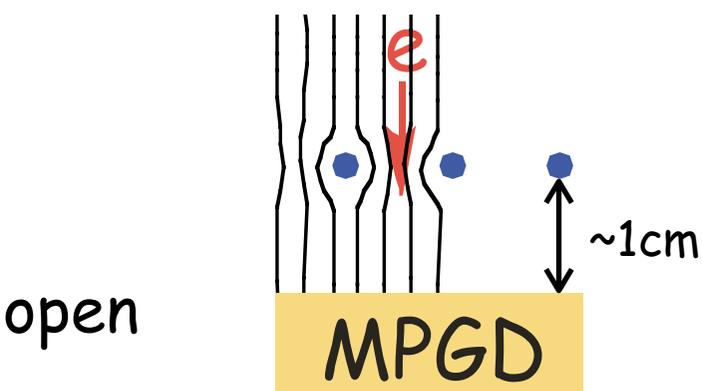
ILC case : ions feedback must be smaller than 10^{-3} (ie. no ions from MPGD)

Gate can be open for 1 msec and be closed following 199 msec.

ion can drift < 1cm

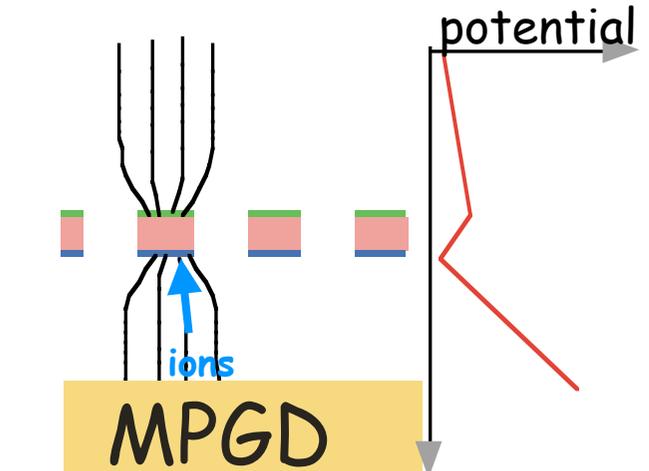
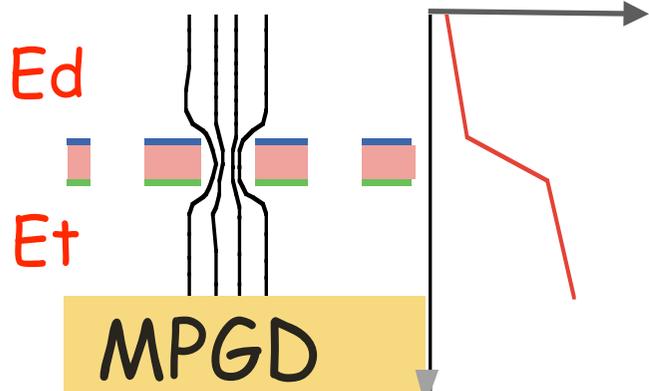
Gate: wire

3 candidates



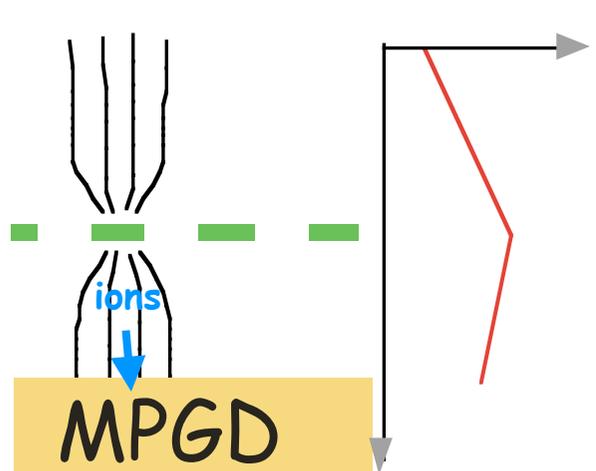
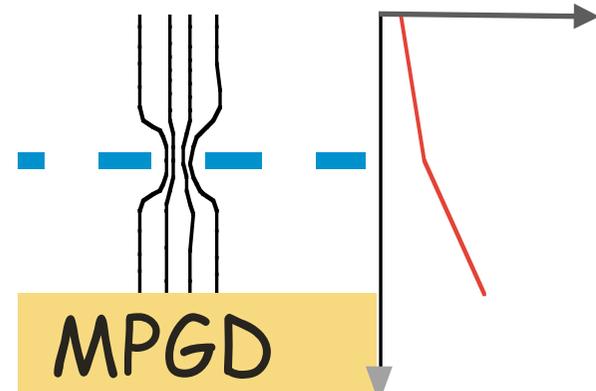
local change of E
wire tension

GEM



local change of E
electron transmission

micromesh

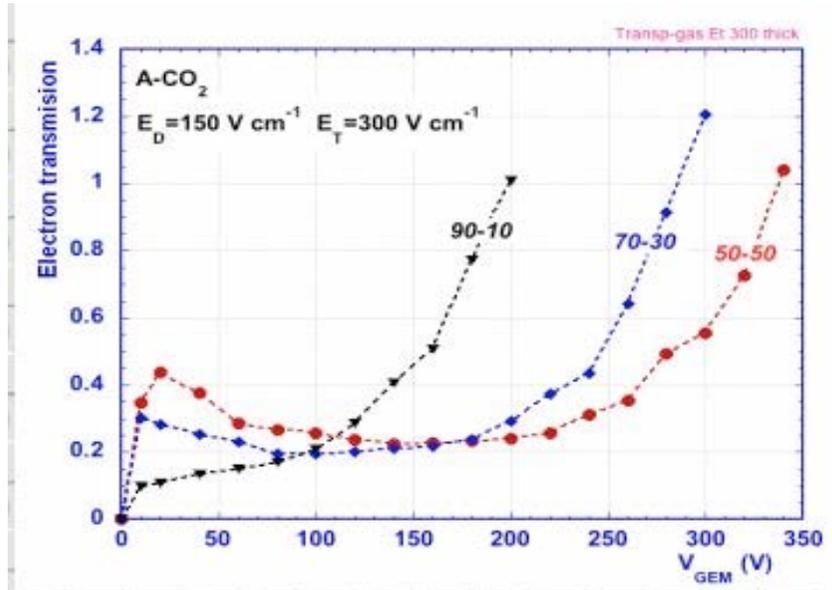


change of drift E
electron transmission

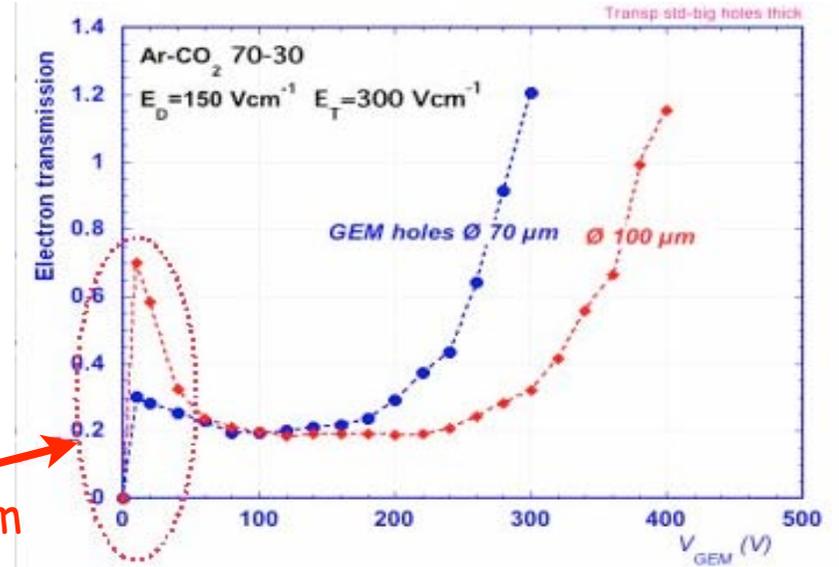
GEM gating

F. Sauli had proposed GEM as gating device @LBLTPC'06

Electron transmission had been measured as a function of V_{GEM} for different Gas mixture



for different hole size



10V/50 μm
 $\sim 2 \text{ kV/cm}$

Low voltage operation may give us good electron transmission: where no gas amplification happen.

We hope to understand this mechanism and optimize GEM for ILC gate
E field calculation and electron simulation in gas help us to do this.

Maxwell3D

Garfield

We have to make sure these tools provide correct answer

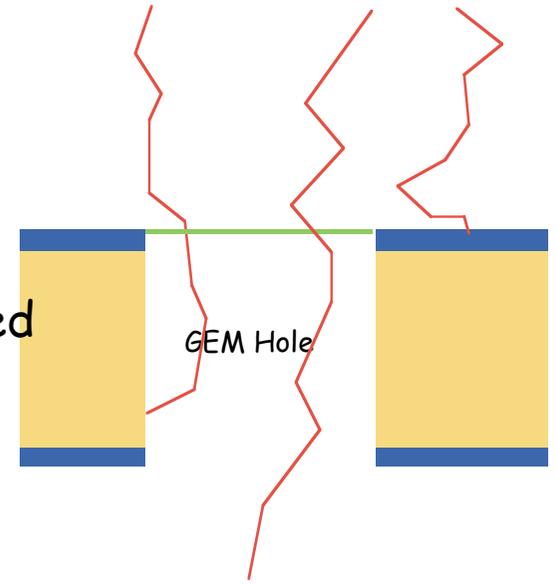
How do we understand electron transmission through simulation

Transmission = Collection eff. x Extraction eff.

Collection eff. = #e reached to entrance of hole/#e generated

Extraction eff. = #e extracted from hole/#e reached to ent.

electrons are generated 500um above GEM surface uniformly.



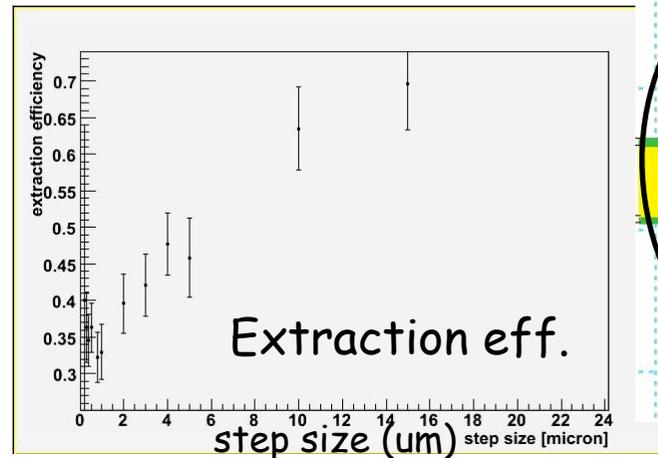
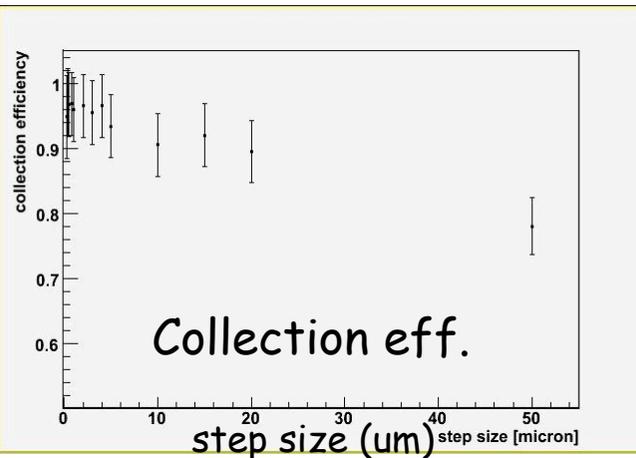
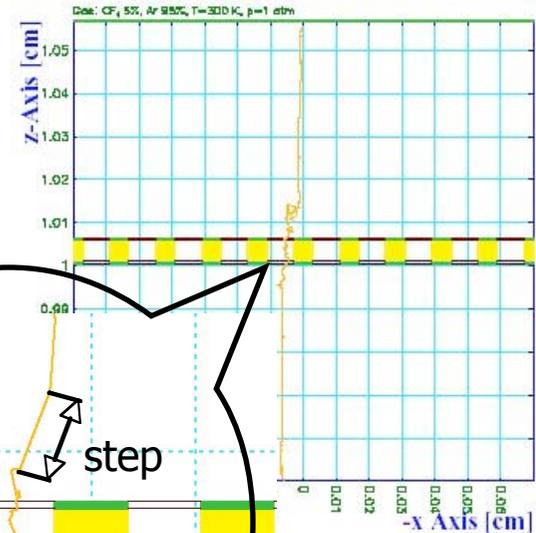
Important parameter of Garfield is **STEP SIZE**

step size : interval to update electron position

step size is controlled by # of collisions OR length.

large step size -> incorrect result

too small step size -> cal. stopped by Max. number(1000)



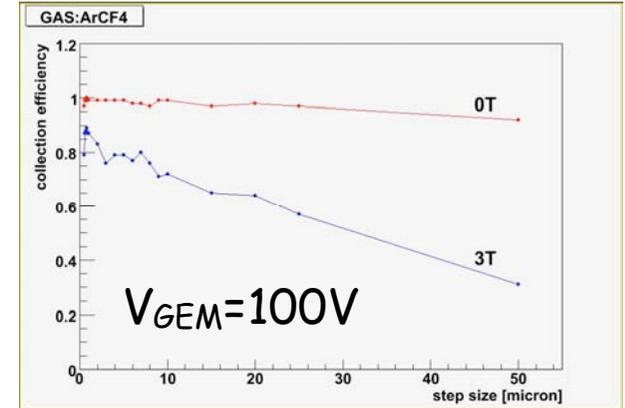
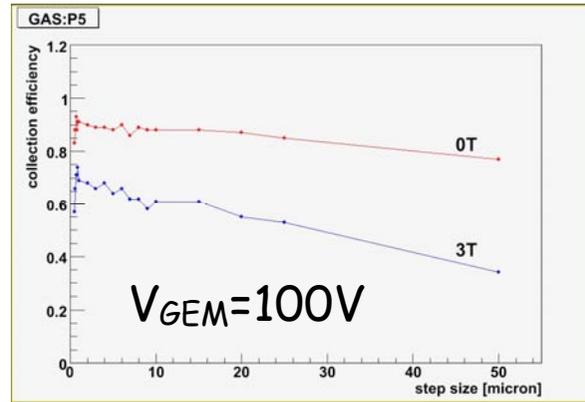
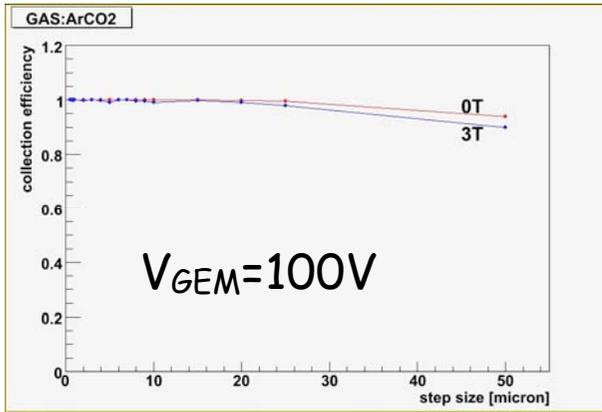
More example of step size effect

Ar:CO₂

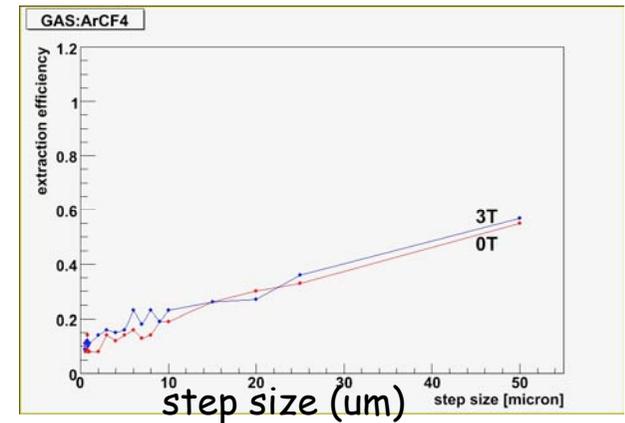
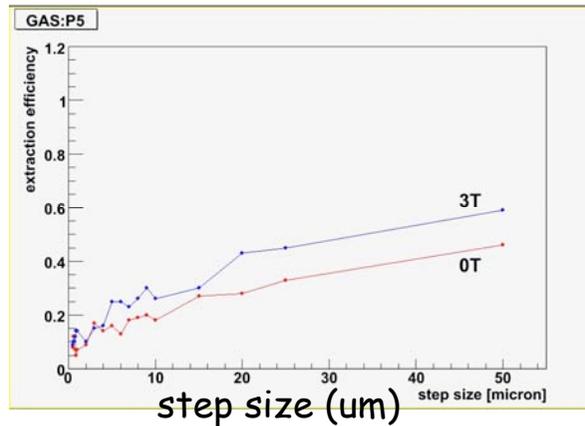
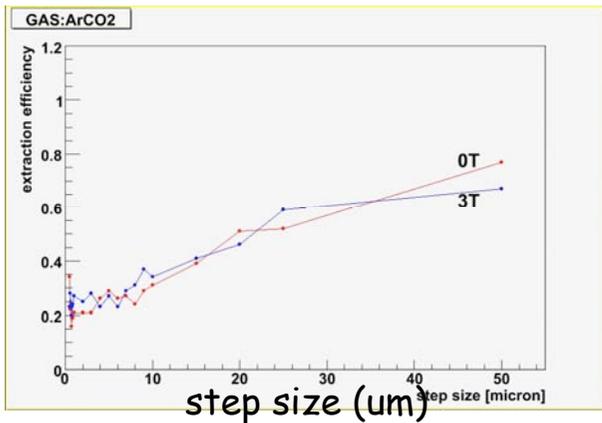
Ar:CH₄(P5)

Ar:CF₄

collection eff.

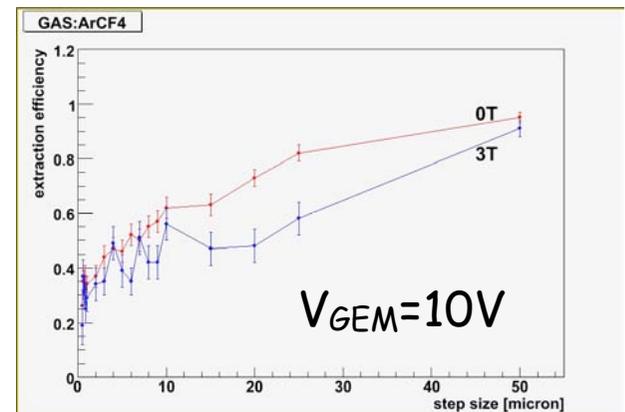


extraction eff.



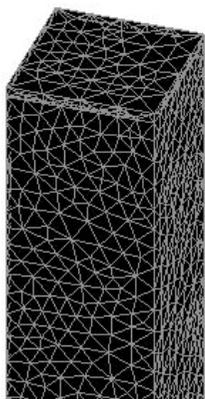
In any case, result change as step size
result @ 0 step size must be close to true value !

We chose 2 um step size
as the result may be close enough to true answer

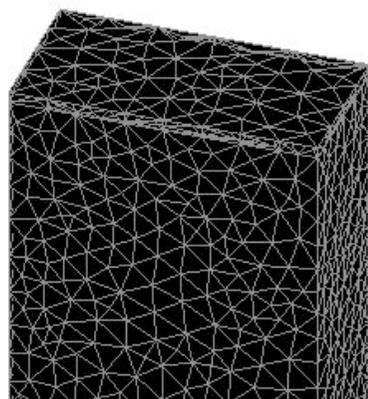


Size of Field map

Field map used in garfield can be provided from Maxwell3D.
but acceptable size is limited to $\sim 10^5$ elements



Blue line



Red line

mesh size $\sim 2 \times$ Blue

Collection eff. is same each other

ie. E field @ collection seems to be precise enough

Extraction eff. provides $\sim 10\%$ diff.

ie. E field is not precisely calculated in hole

or interpolation of E field doesn't work in garfield

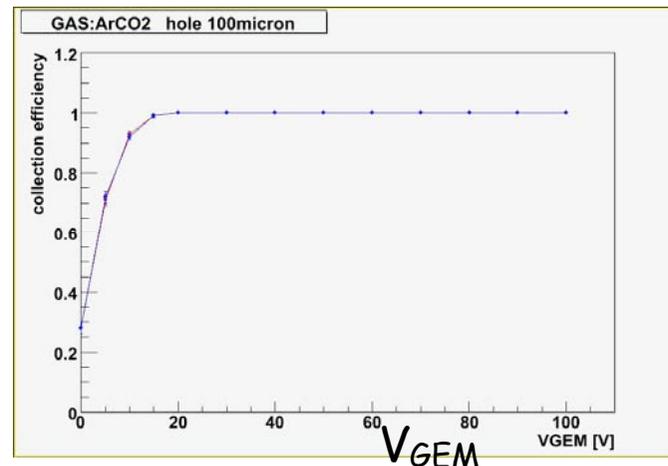
In Maxwell3D, mesh is automatically generated
we cannot quote exact volume of mesh

We have to remember accuracy of result

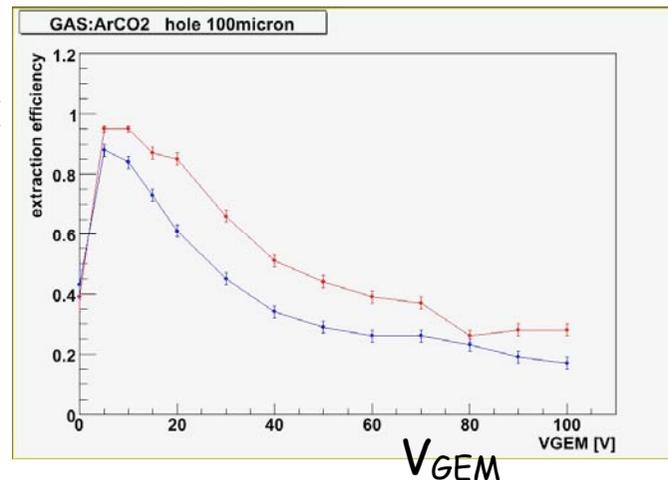
when we use garfield

ArCO2

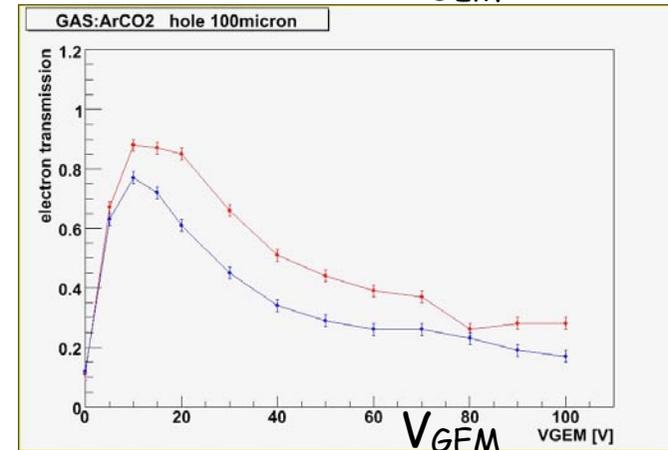
collection eff.



extraction eff.



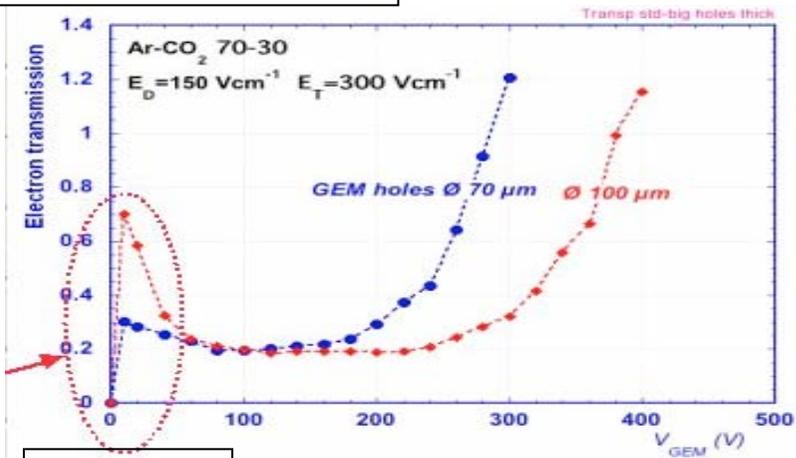
transmission



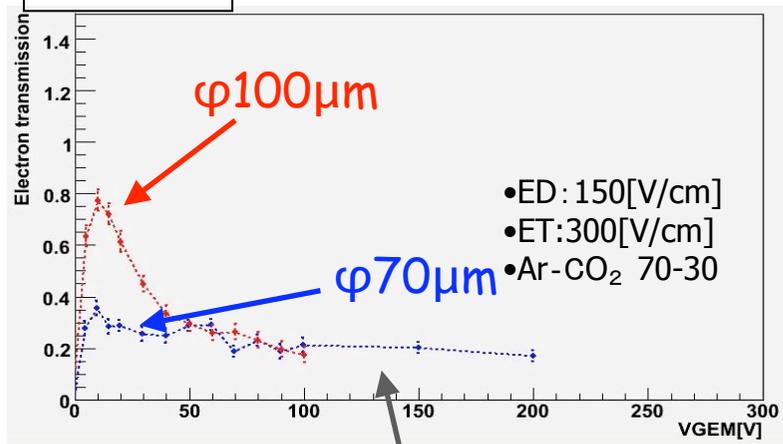
Comparison to exp. results

Electron transmission
Hole size dep.

Measurement by Sauli



simulation



Gas gain is not included

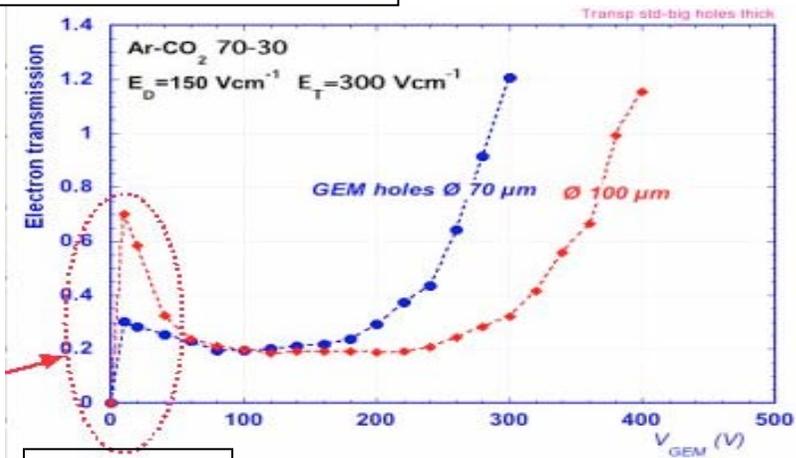
Simulation results are reproduced well !!

if we convert transmission into detail

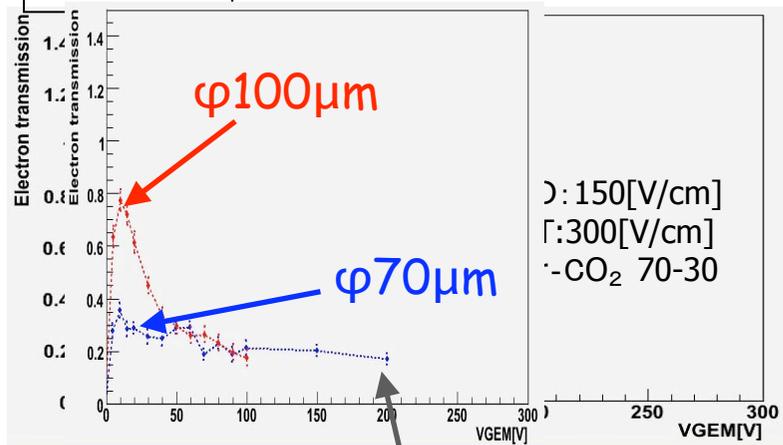
Comparison to exp. results

Electron transmission
Hole size dep.

Measurement by Sauli



simulation



Gas gain is not included

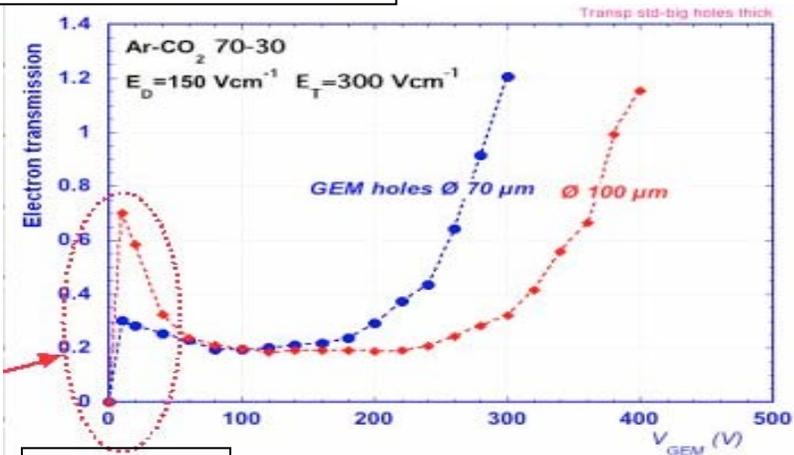
Simulation results are reproduced well !!

if we convert transmission into detail

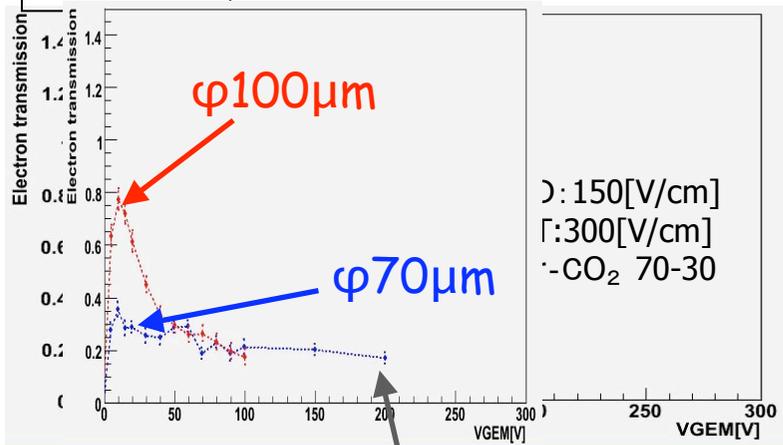
Comparison to exp. results

Electron transmission
Hole size dep.

Measurement by Sauli

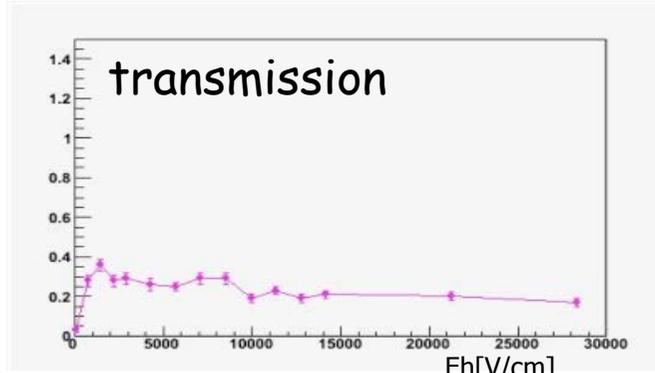
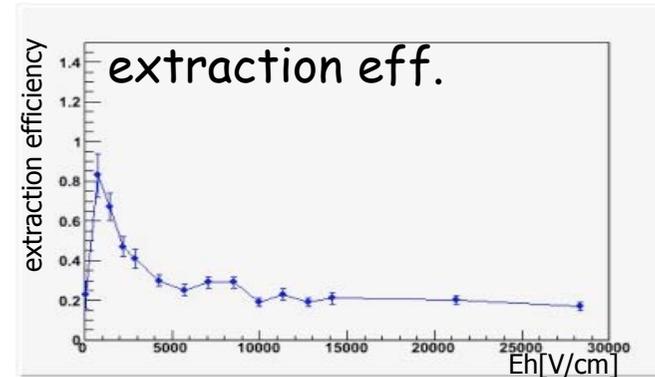
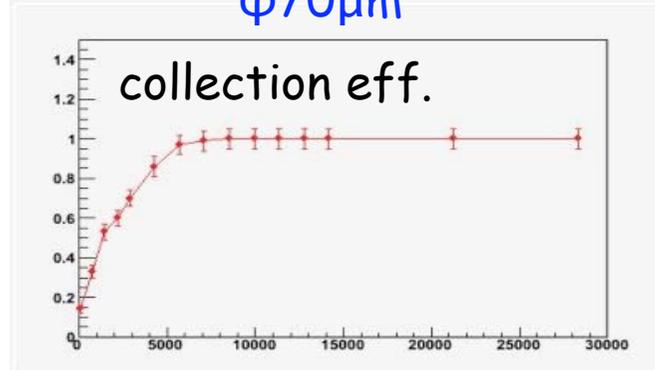


simulation



Gas gain is not included

ϕ 70 μ m



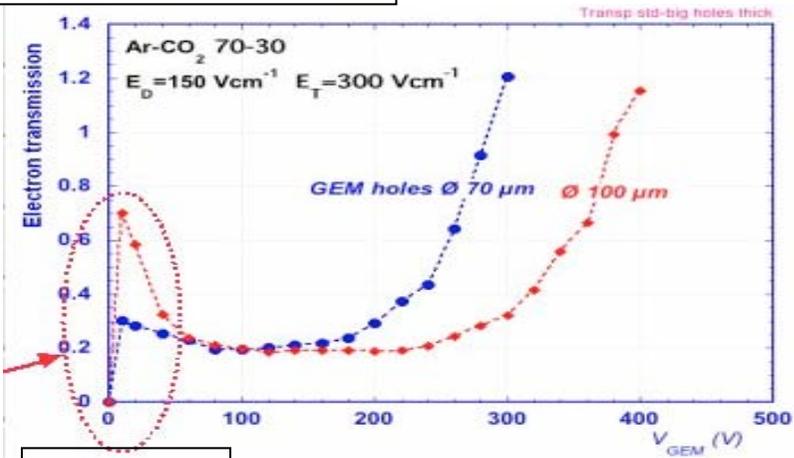
roduced well !!

sion into detail

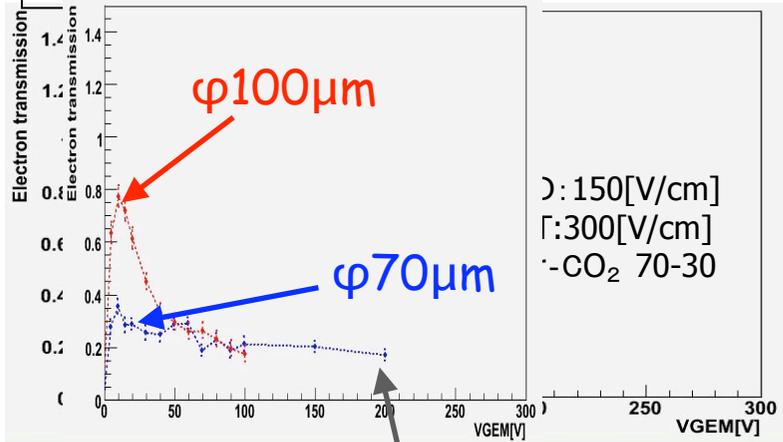
Comparison to exp. results

Electron transmission
Hole size dep.

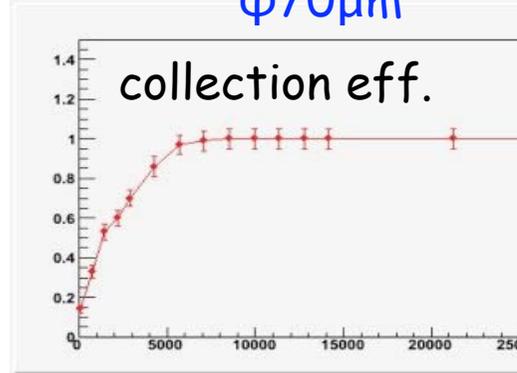
Measurement by Sauli



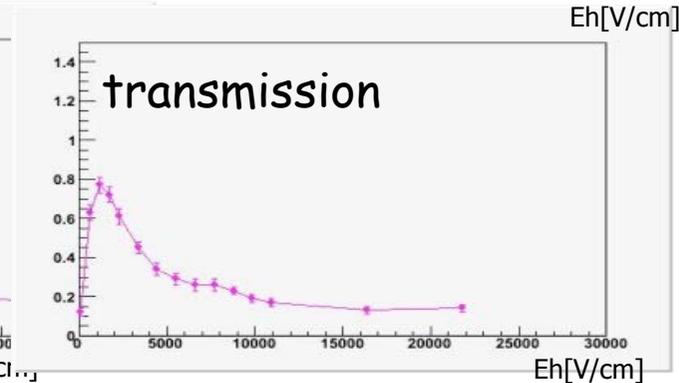
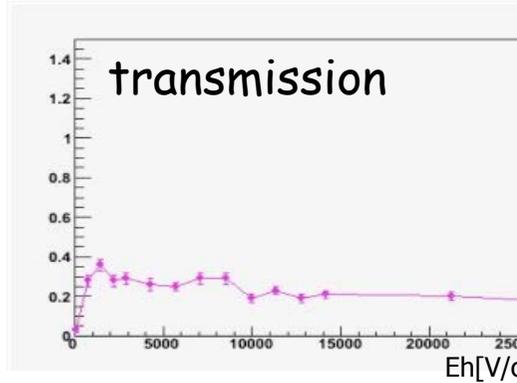
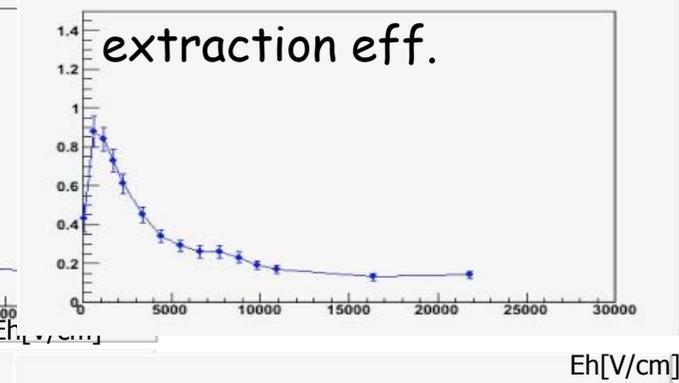
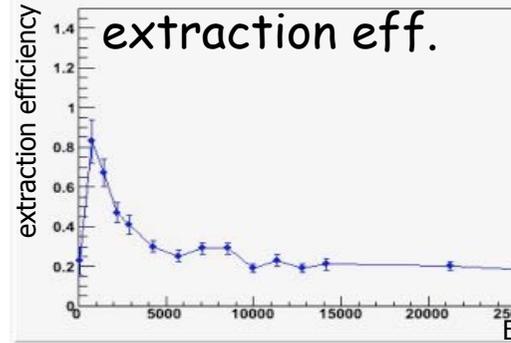
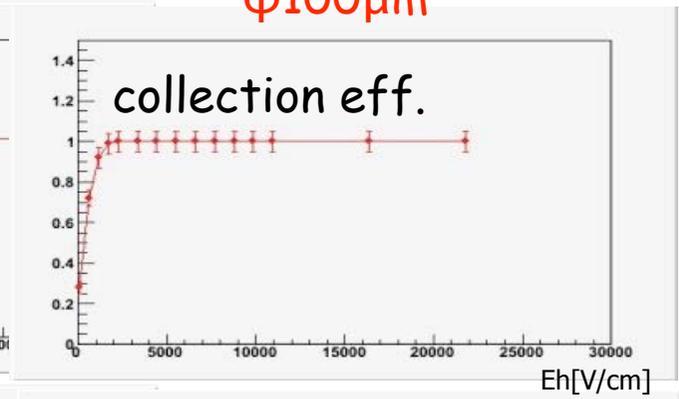
simulation



ϕ 70 μ m



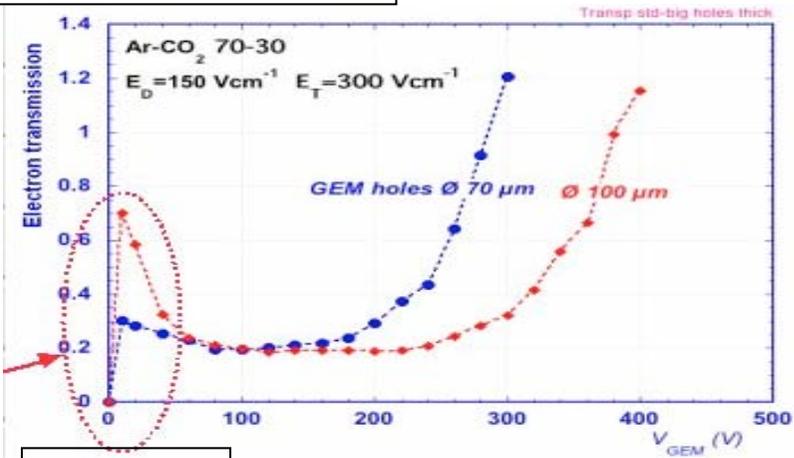
ϕ 100 μ m



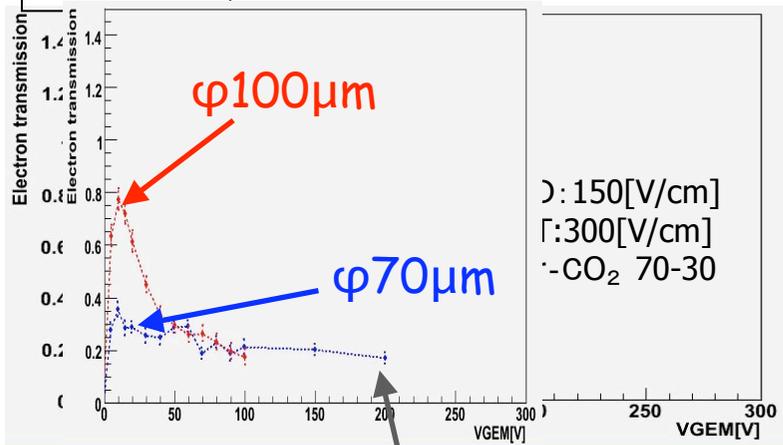
Comparison to exp. results

Electron transmission
Hole size dep.

Measurement by Sauli

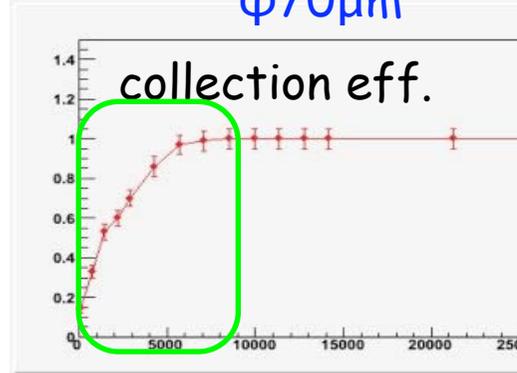


simulation

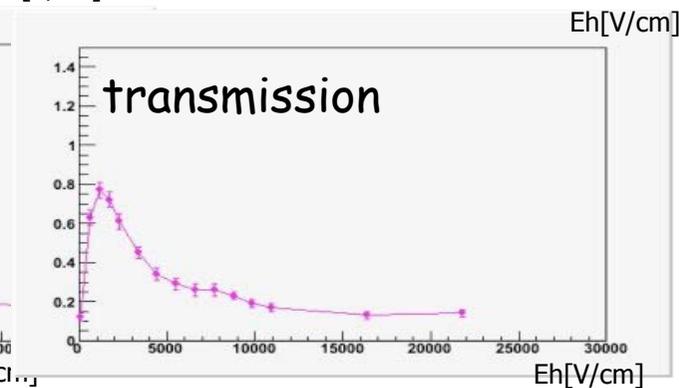
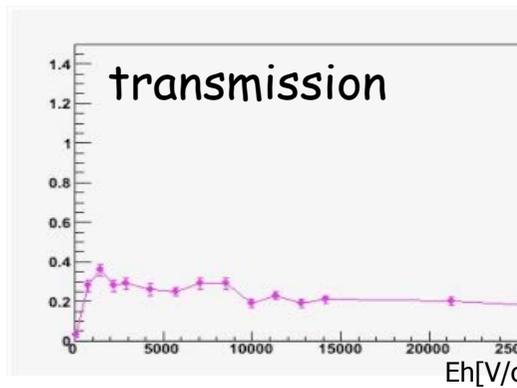
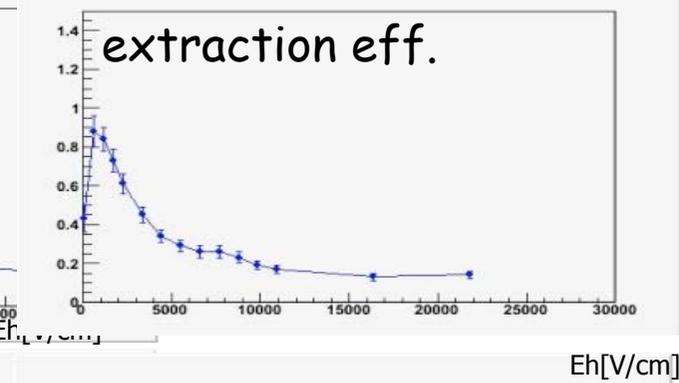
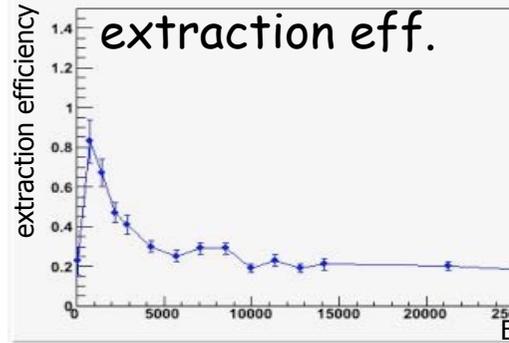
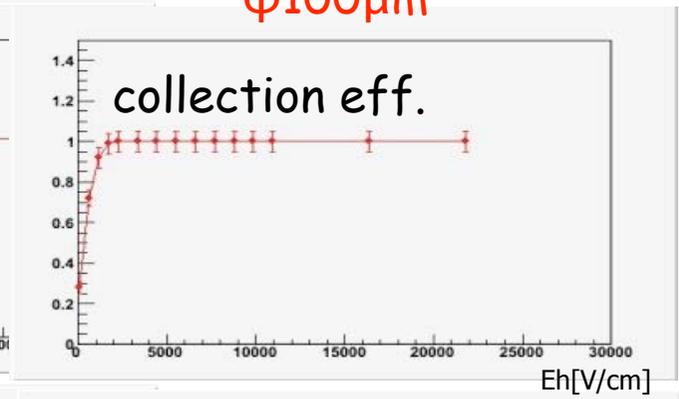


Gas gain is not included

ϕ 70 μ m



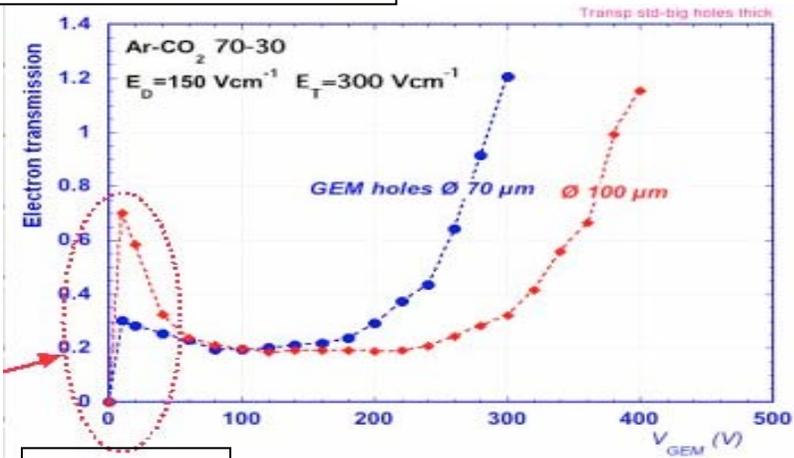
ϕ 100 μ m



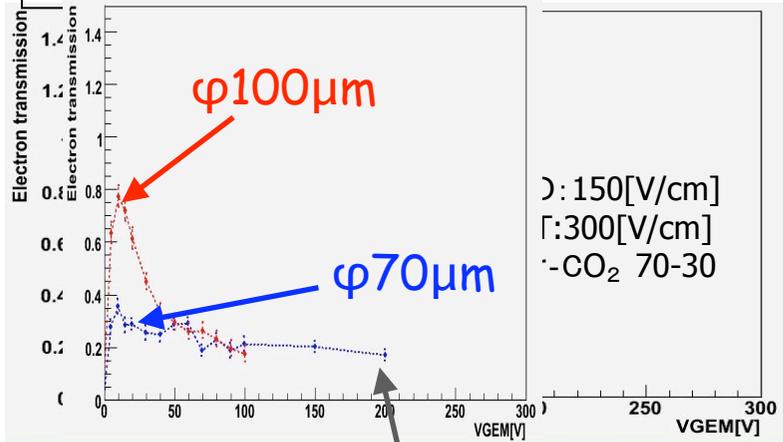
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Hole size dep.

Measurement by Sauli

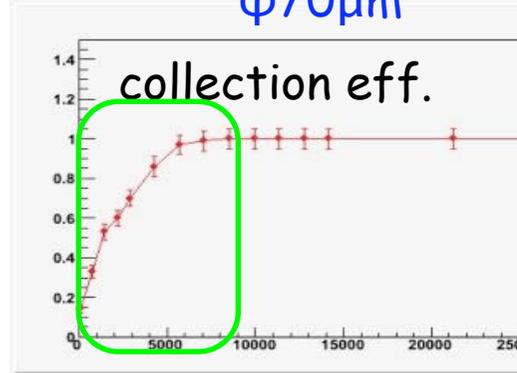


simulation

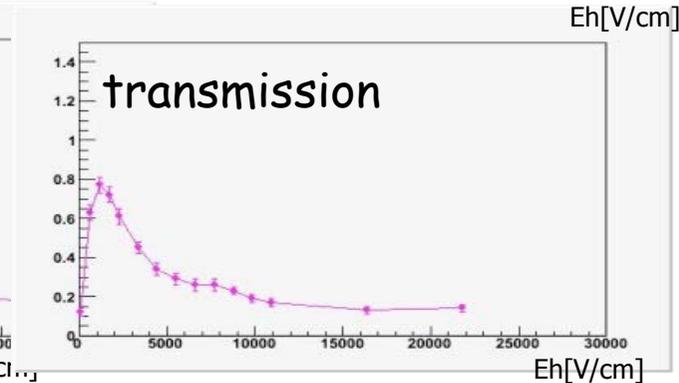
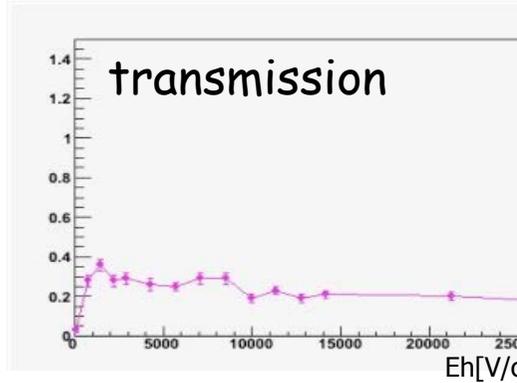
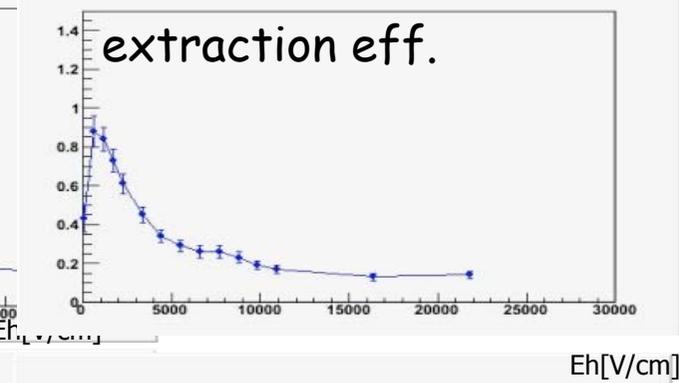
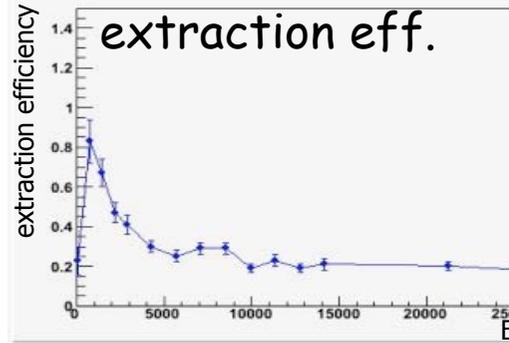
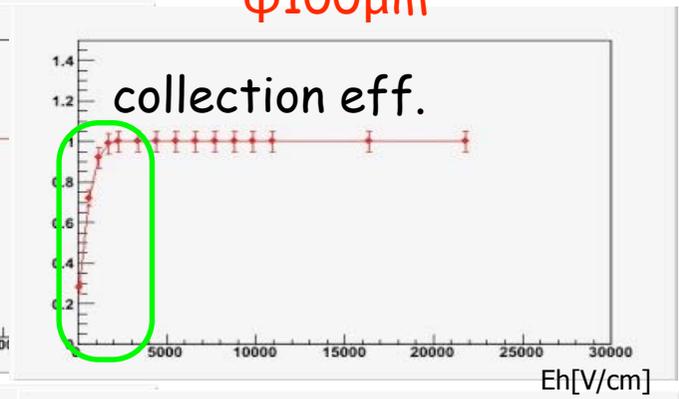


Gas gain is not included

ϕ 70 μ m



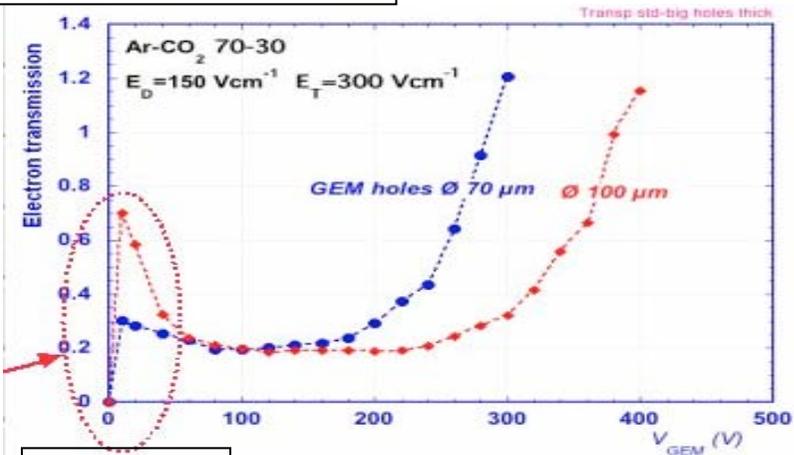
ϕ 100 μ m



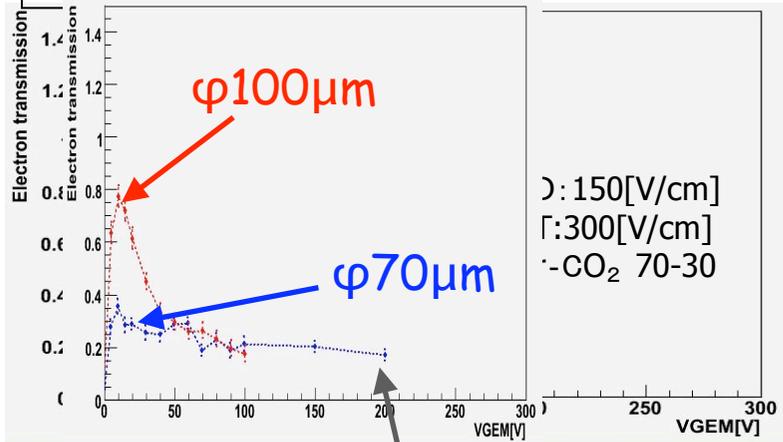
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Electron transmission
Hole size dep.

Measurement by Sauli

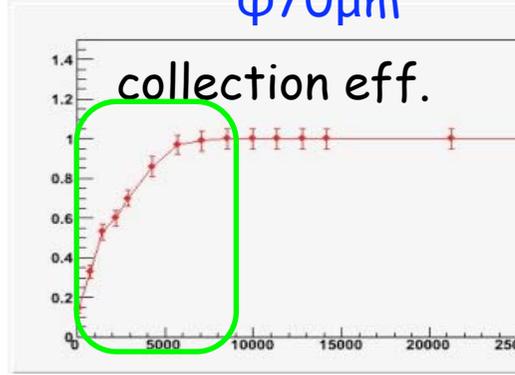


simulation

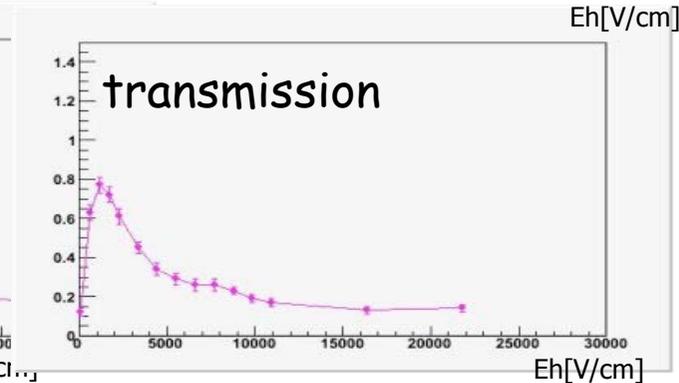
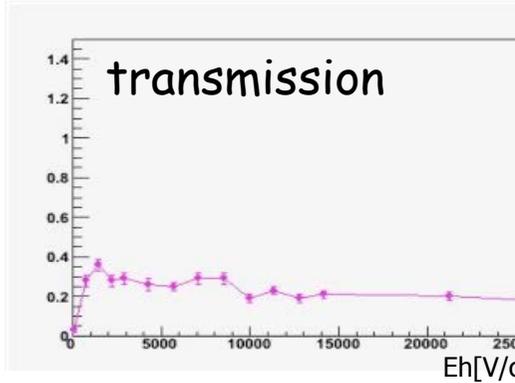
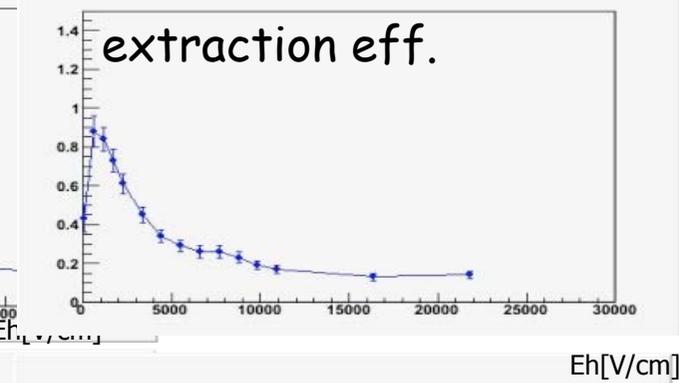
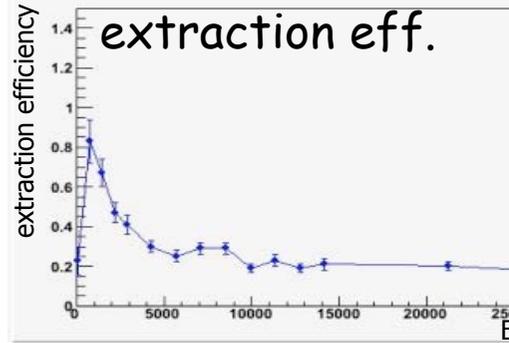
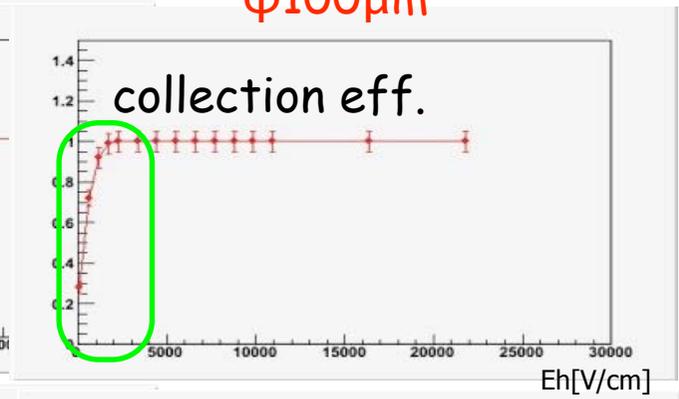


Gas gain is not included

$\phi 70\mu\text{m}$

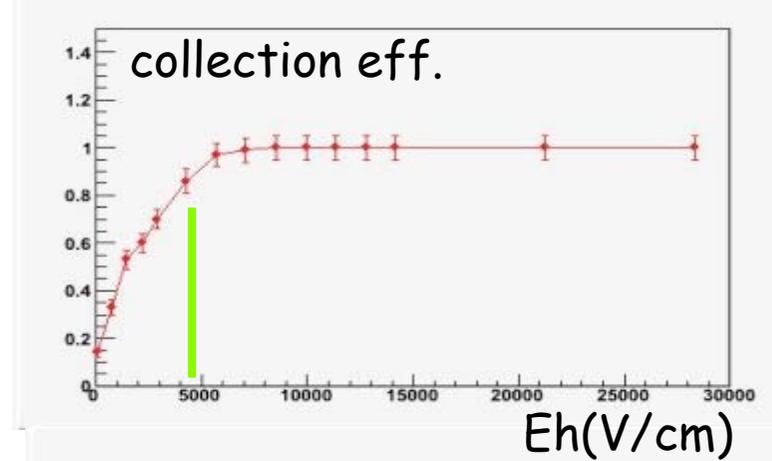


$\phi 100\mu\text{m}$



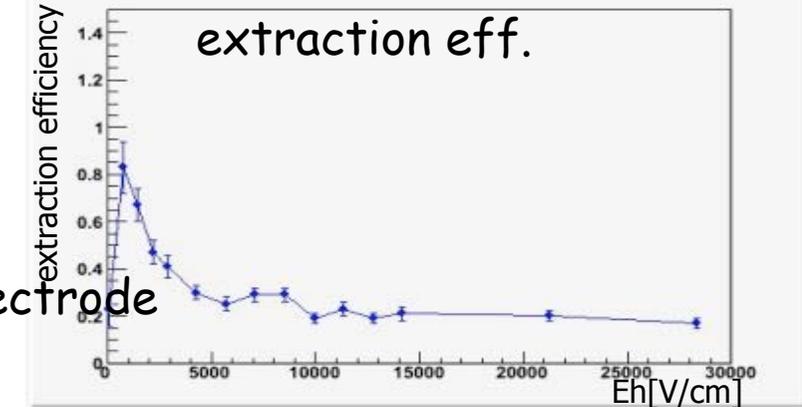
Collection eff. improve transmission
due to large aperture

Collection eff. has been studied by several groups
 as a func. of E_d/E_h
 and known to be ~ 1 @ $E_d/E_h < 0.03$ (ie 4.5kV/cm here)



Extraction eff. behave more more complicatedly

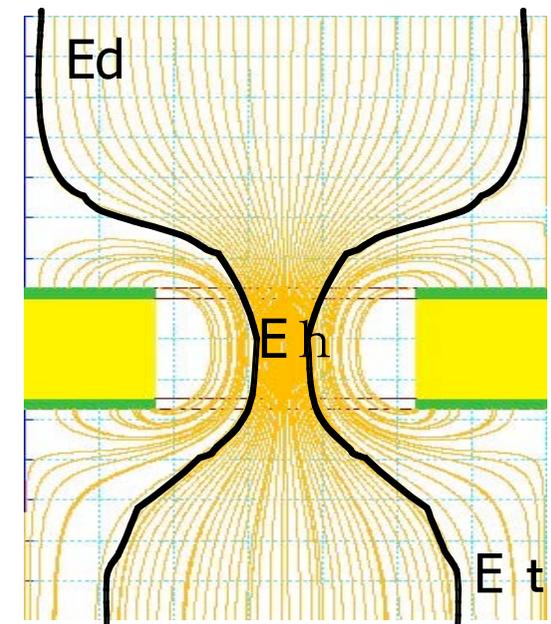
- area of penetrating field line become small as E_h
- electron can spread due to diffusion(E_h)
- some electron follow returned filed line to GEM electrode



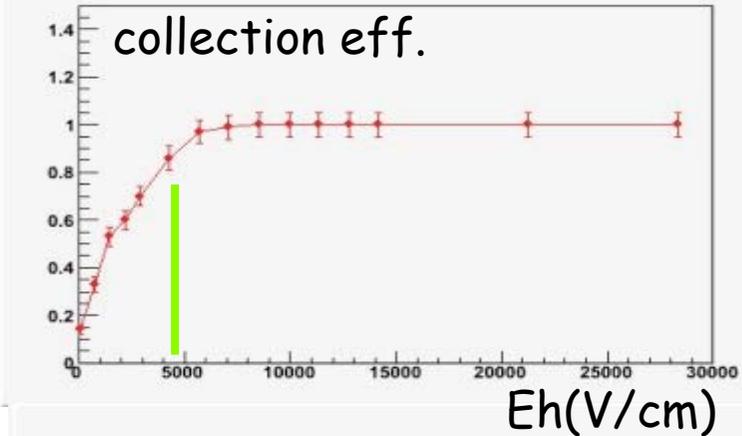
area of penetrating field line is larger @ low E_h
 higher extraction
 diffusion behavior is also important !

This means "transmission is largely depend on gas"

LC also requires High Magnetic Field (3~4 T)

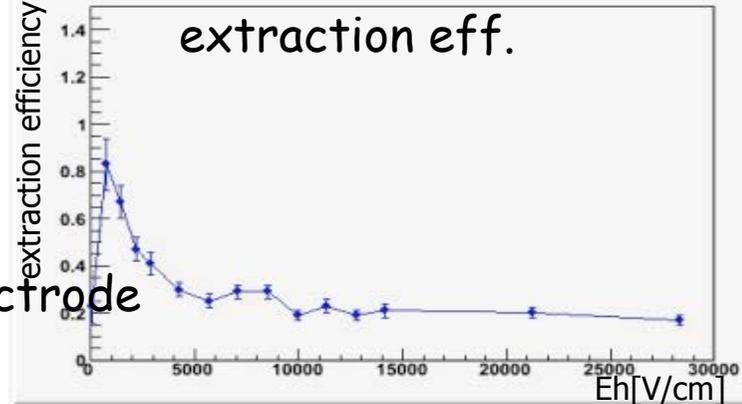


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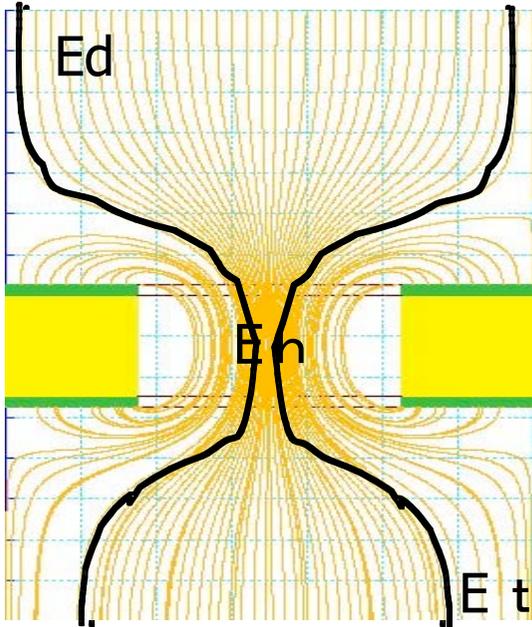
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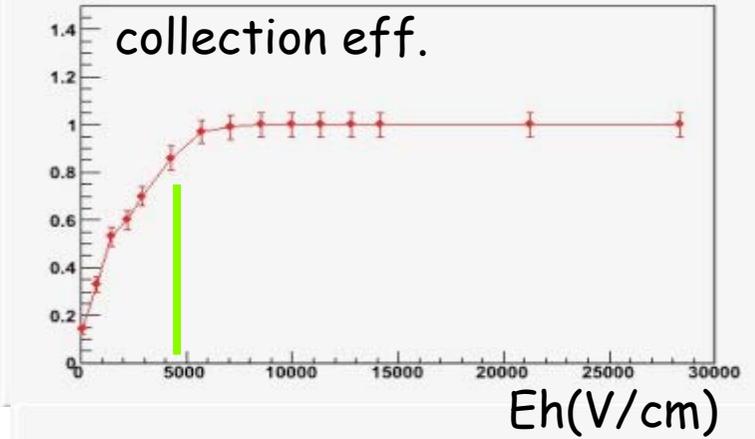
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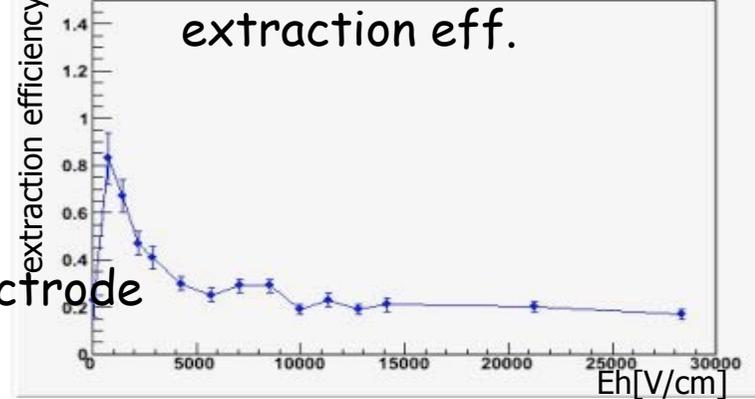


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Extraction eff. behave more more complicatedly

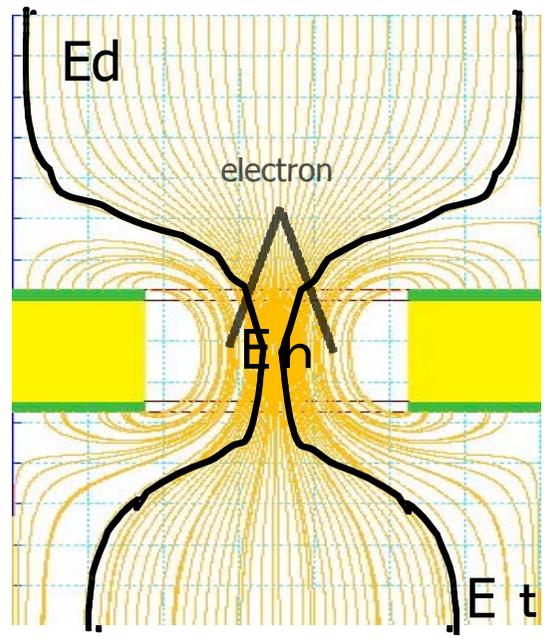
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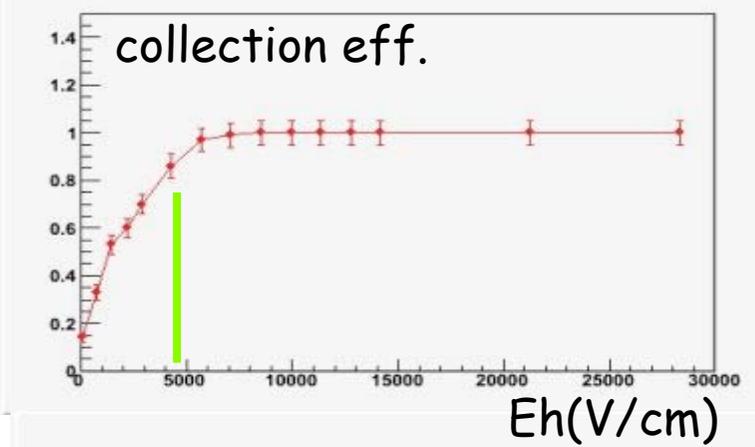
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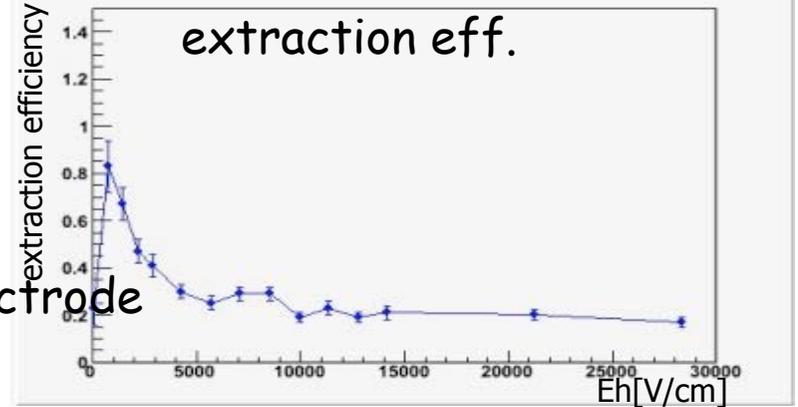


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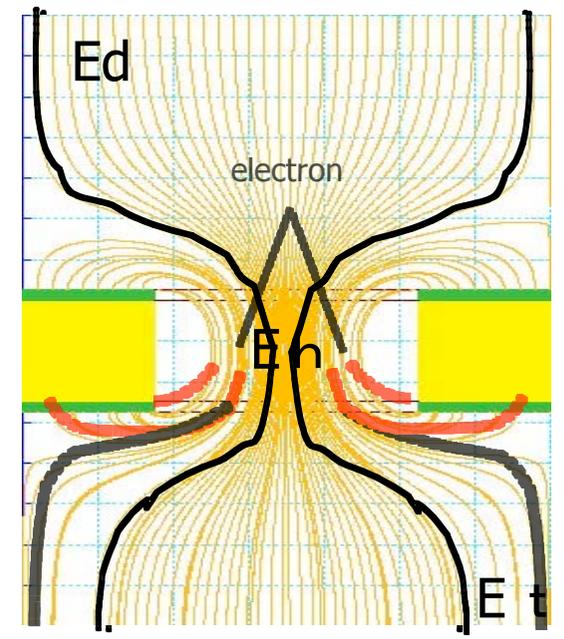
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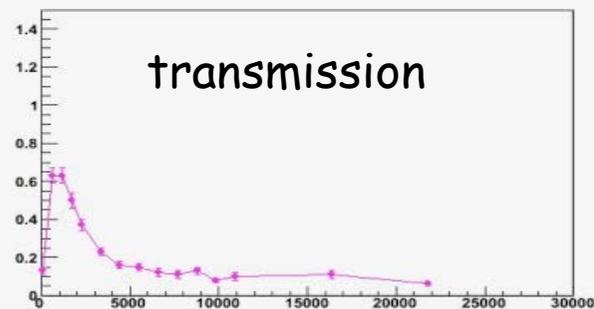
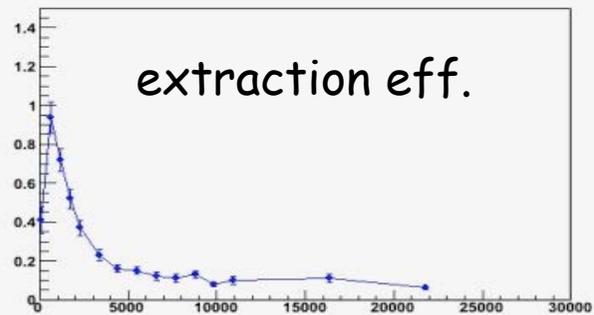
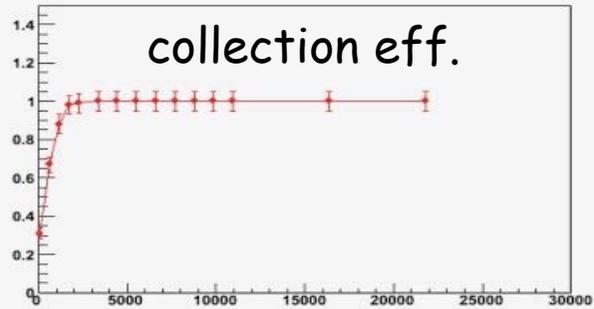
ArCF₄ : candidate of LC-TPC Gas

$E_d = 150 \text{ V/cm}$

$E_t = 300 \text{ V/cm}$

ϕ 100 μm hole

$B = 0 \text{ T}$



E_h (V/cm)

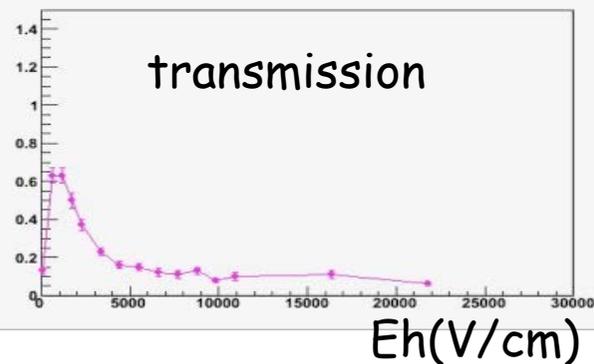
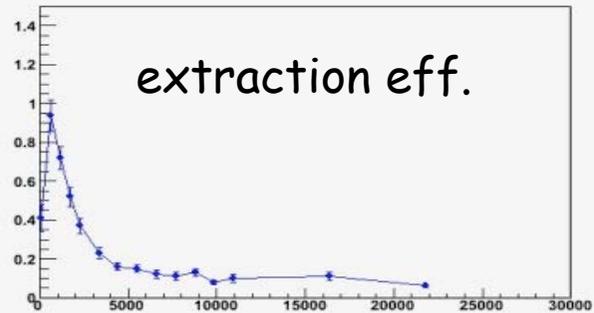
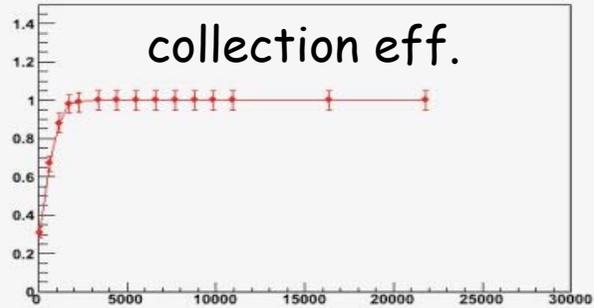
ArCF4 : candidate of LC-TPC Gas

$E_d = 150 \text{ V/cm}$

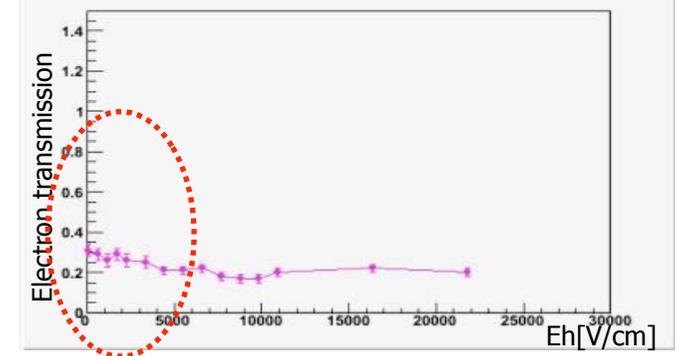
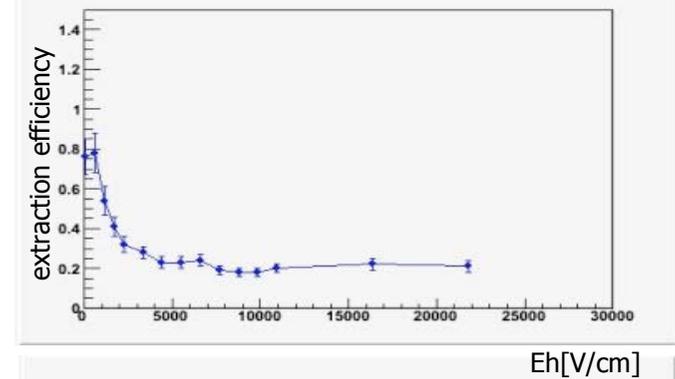
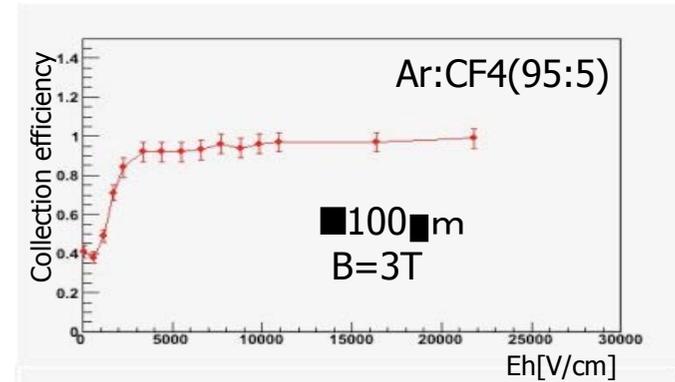
$E_t = 300 \text{ V/cm}$

ϕ 100 μm hole

$B = 0 \text{ T}$



Effect of 3T magnetic field



Good region disappeared !

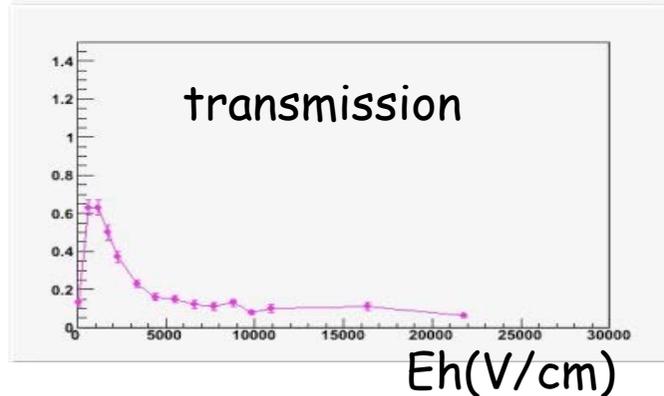
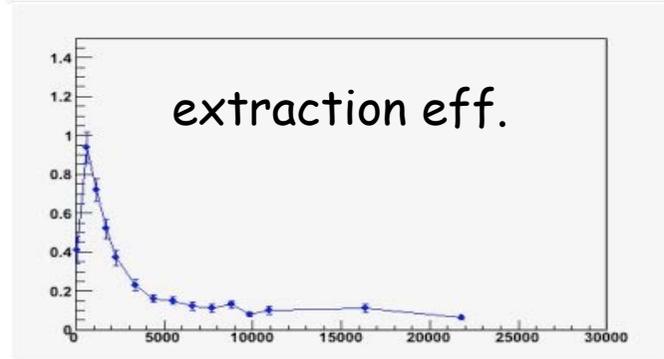
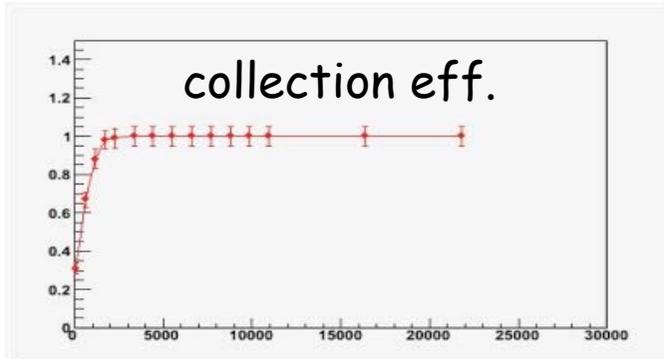
ArCF4 : candidate of LC-TPC Gas

$E_d = 150 \text{ V/cm}$

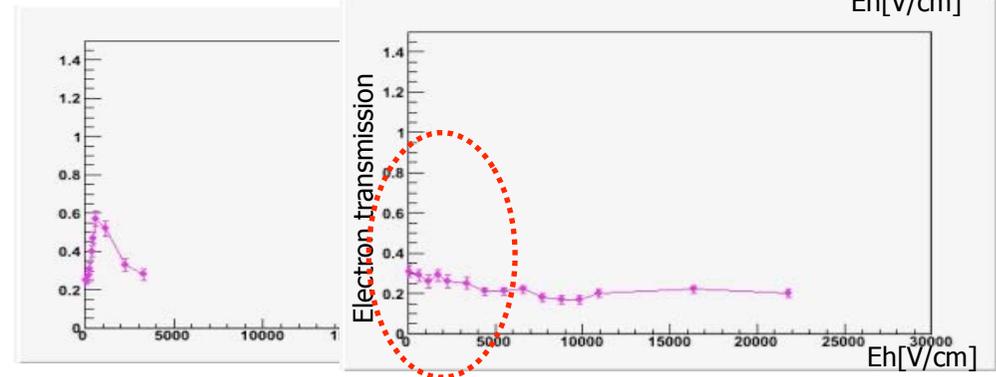
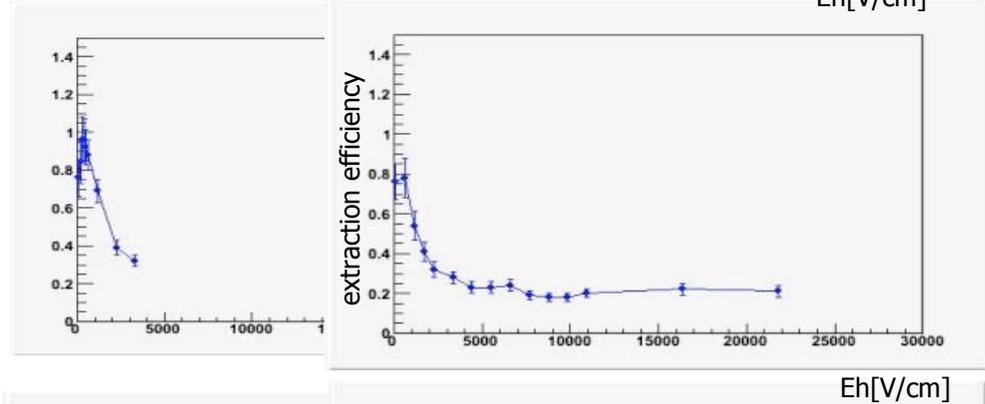
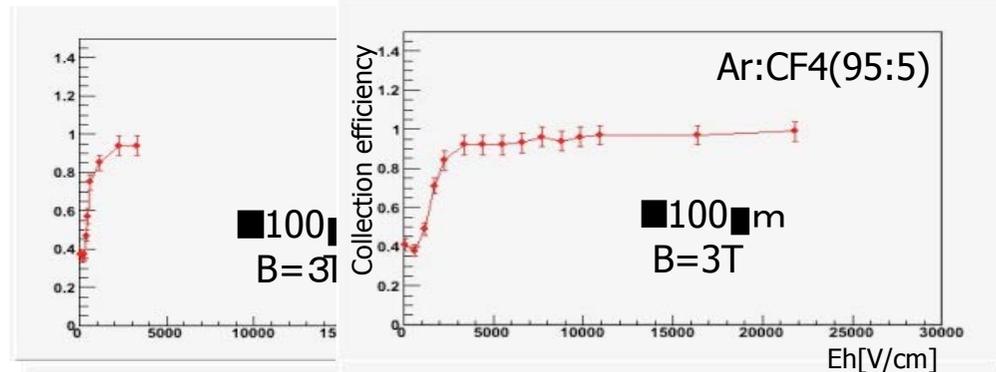
$E_t = 300 \text{ V/cm}$

ϕ 100 μm hole

$B = 0 \text{ T}$



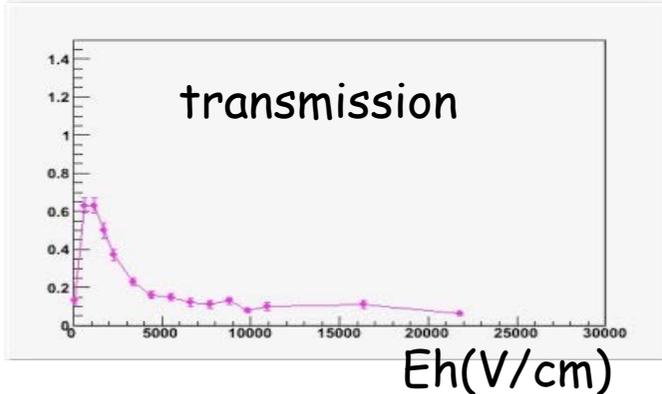
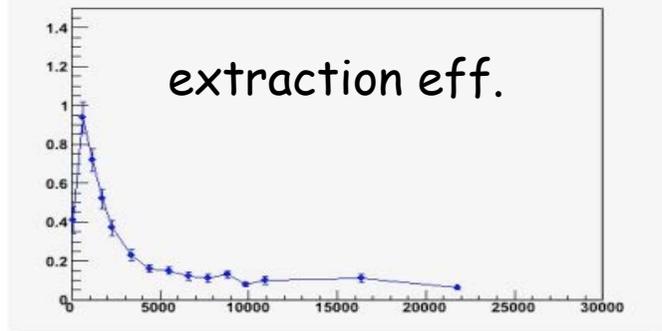
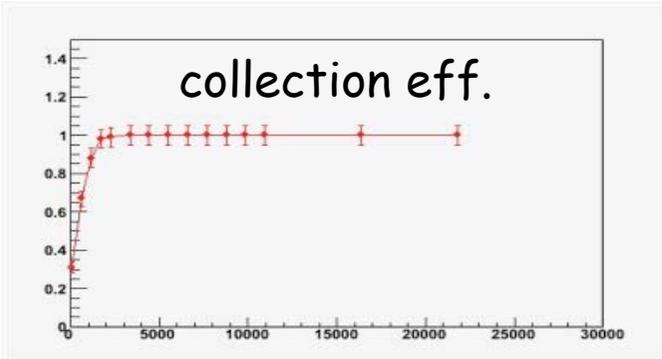
Effect of 3T magnetic field



Good region disappeared !

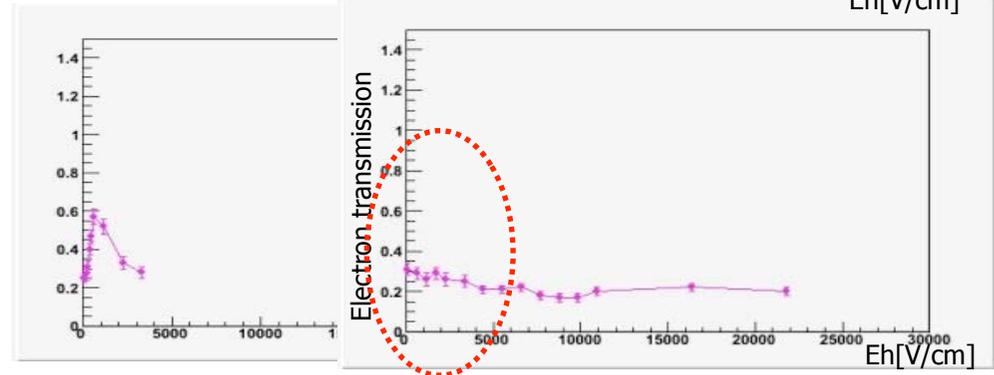
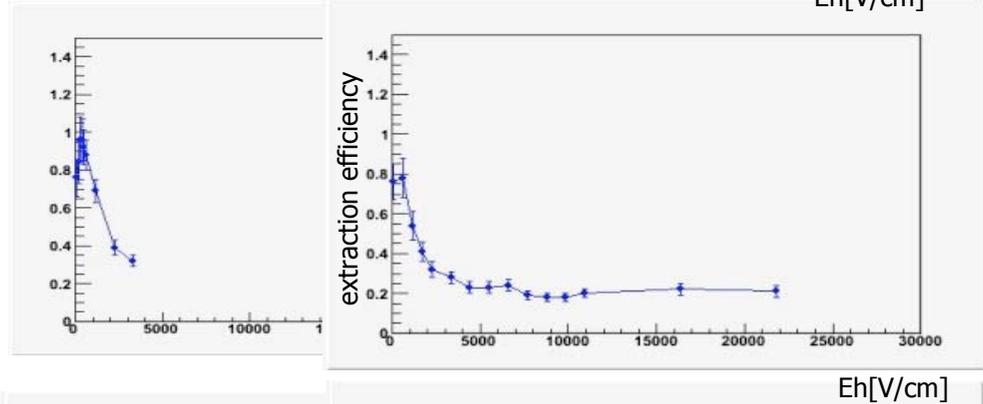
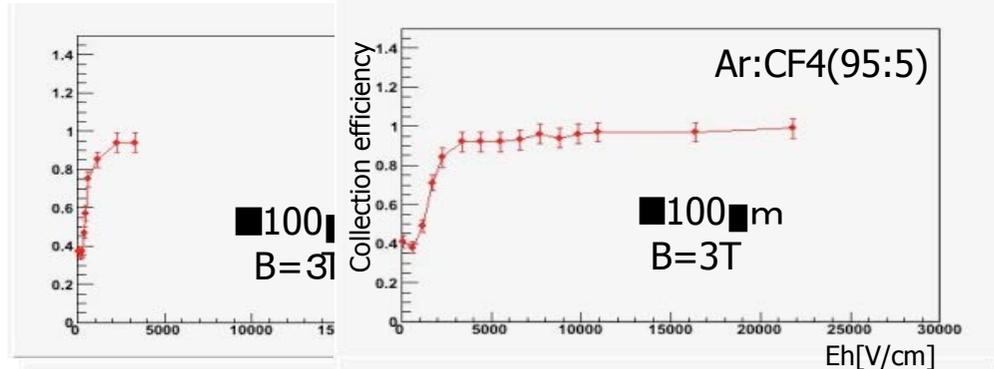
ArCF4 : candidate of LC-TPC Gas

$E_d=150\text{V/cm}$
 $E_t=300\text{V/cm}$
 ϕ 100 μm hole
 $B = 0\text{ T}$



$E_d= 50\text{V/cm}$
 $E_t=300\text{V/cm}$
 $B = 3\text{ T}$

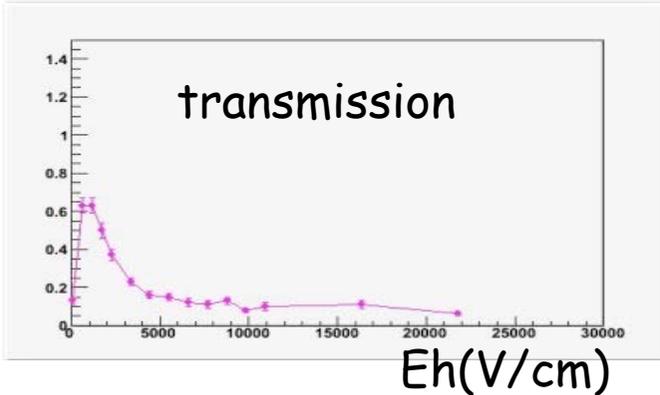
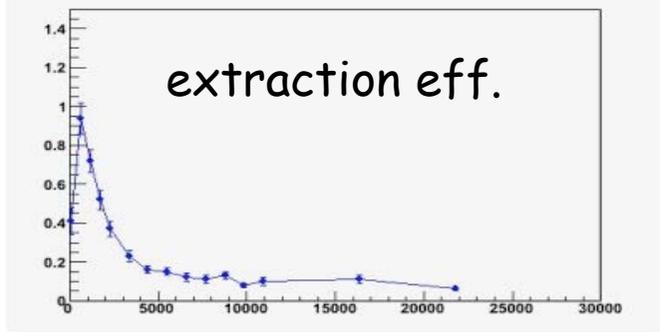
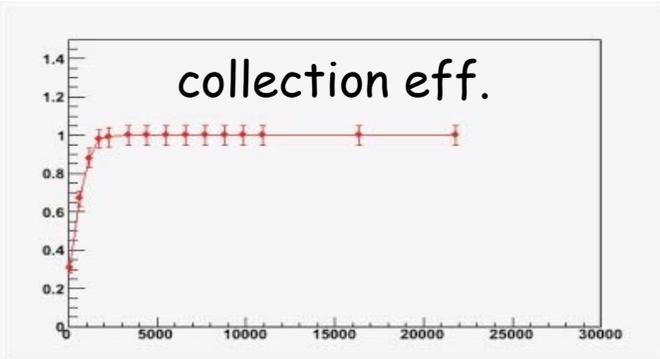
Effect of 3T magnetic field



Good region disappeared !

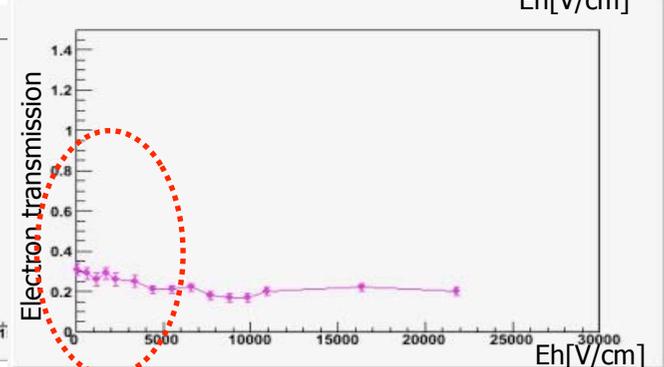
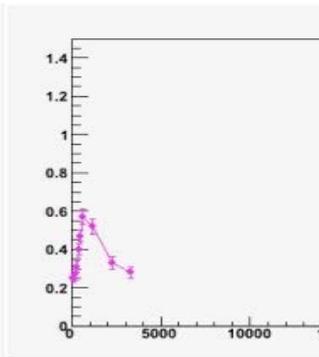
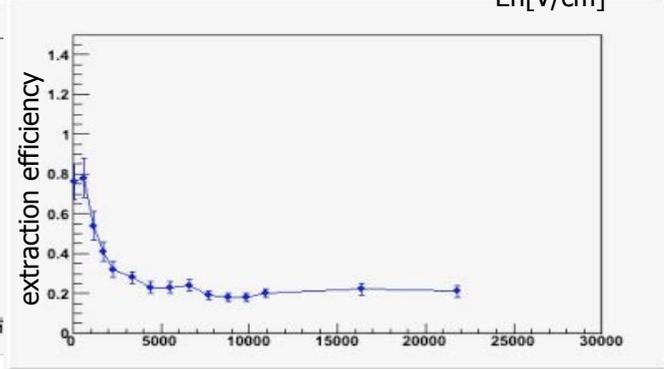
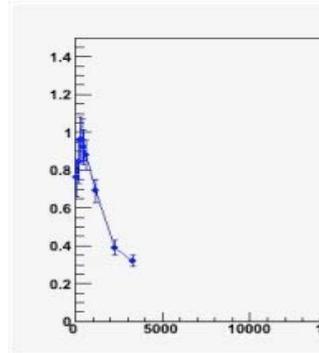
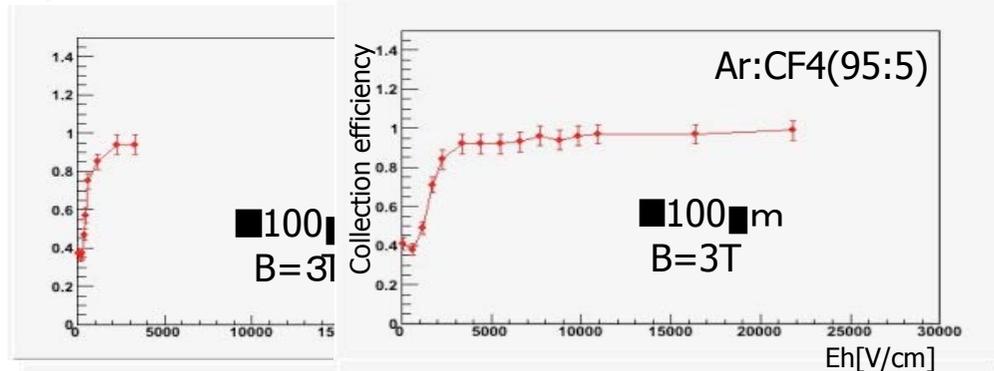
ArCF4 : candidate of LC-TPC Gas

$E_d = 150 \text{ V/cm}$
 $E_t = 300 \text{ V/cm}$
 $\phi = 100 \mu\text{m}$ hole
 $B = 0 \text{ T}$



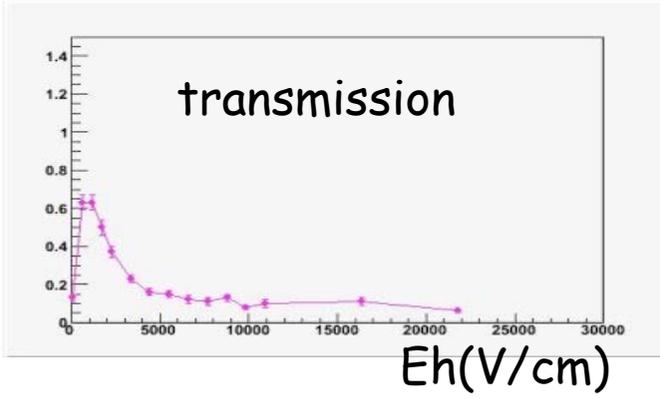
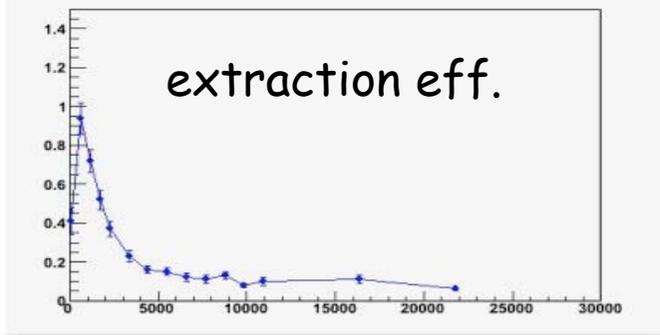
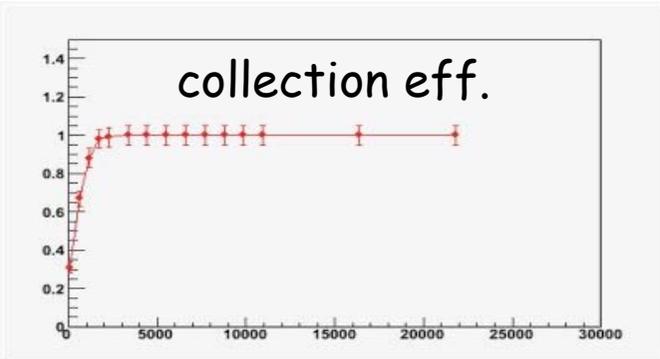
$E_d = 50 \text{ V/cm}$
 $E_t = 300 \text{ V/cm}$
 $B = 3 \text{ T}$

Effect of 3T magnetic field



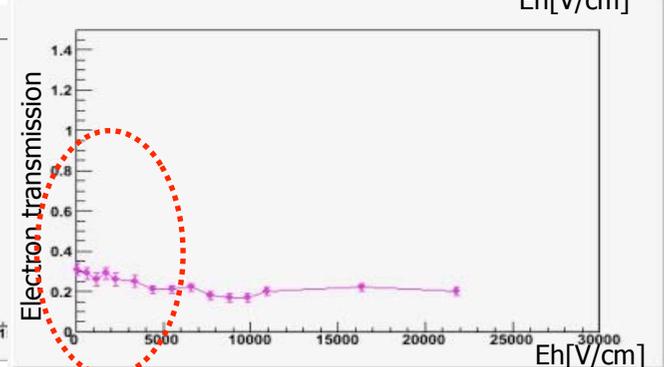
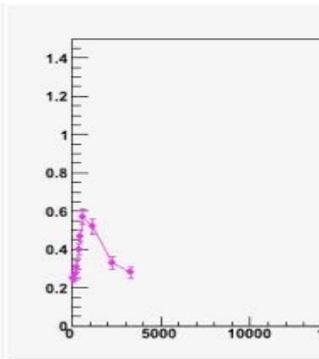
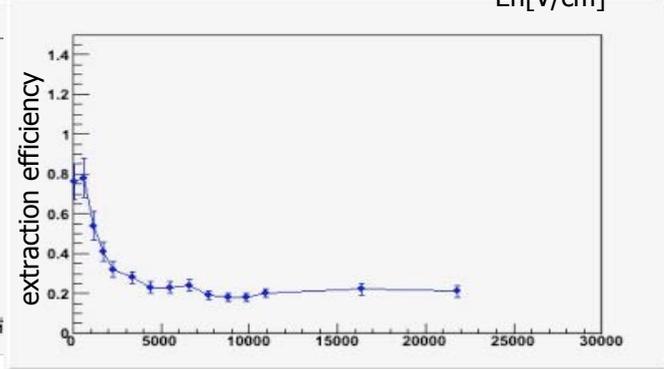
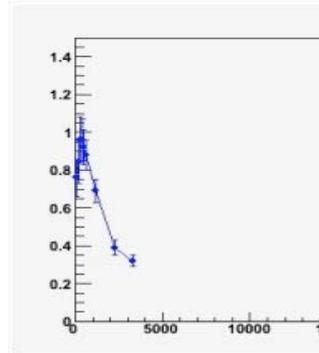
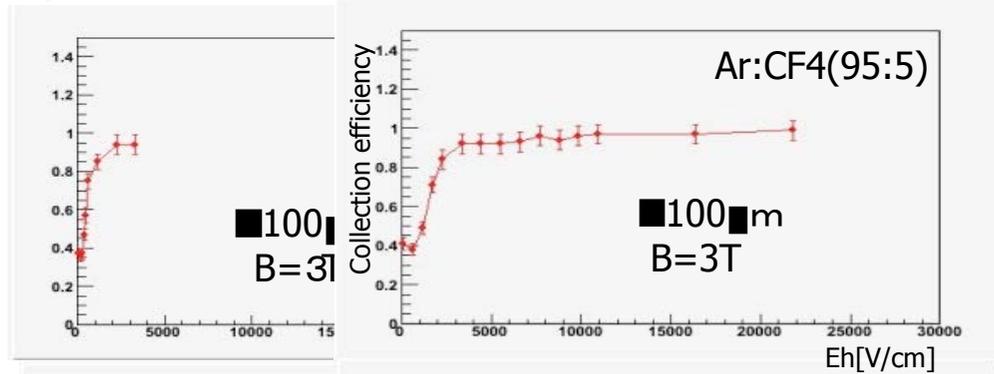
ArCF4 : candidate of LC-TPC Gas

$E_d = 150 \text{ V/cm}$
 $E_t = 300 \text{ V/cm}$
 $\phi = 100 \mu\text{m}$ hole
 $B = 0 \text{ T}$



$E_d = 50 \text{ V/cm}$
 $E_t = 300 \text{ V/cm}$
 $B = 3 \text{ T}$

Effect of 3T magnetic field



transmission is recovered by changing E_d

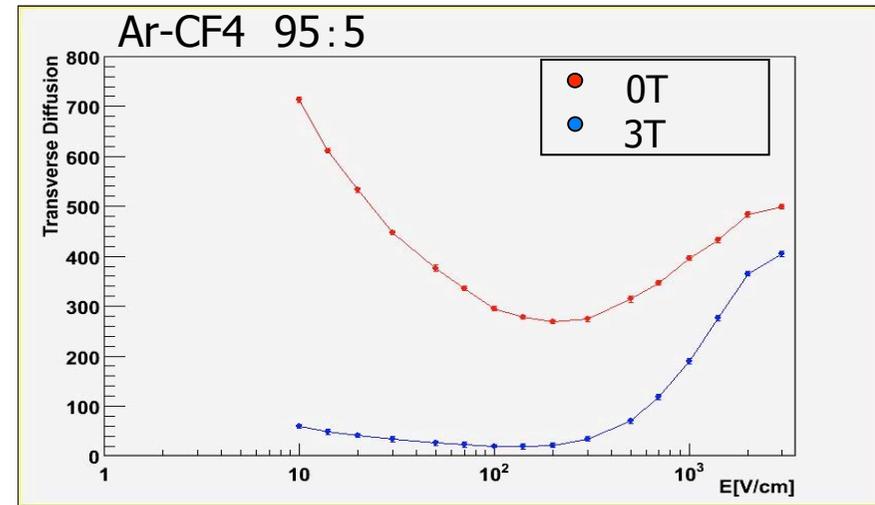
GEM Gating for ArCF4 gas

under this condition
is not good enough for LC-TPC
due to low transmission (~60%)

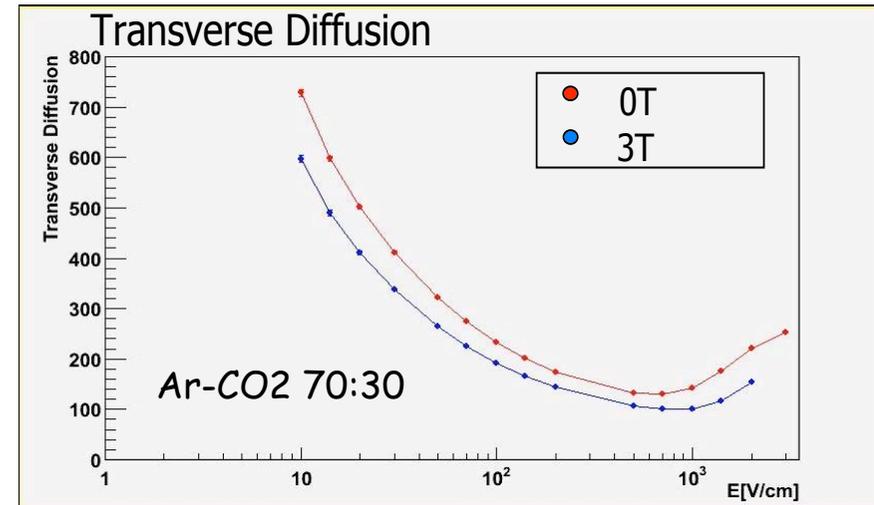
ArCO2 can provide better performance
these results are related to gas property

We must find **better geometry of GEM(width, pitch, hole size)**
or find better operation condition
or find better gas

Otherwise go to other gating method



1.5kV/cm



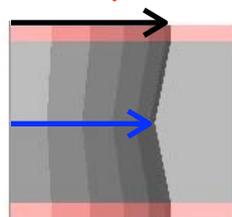
GEM optimization for Gating

1. Hole shape
2. Hole Size/pitch
3. thickness

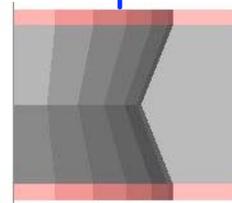
We just begun !

bi-conical shape
outer $\phi=100\ \mu\text{m}$

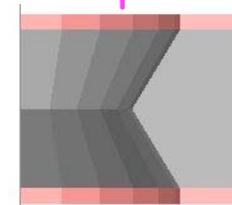
inner $\phi=90\ \mu\text{m}$



inner $\phi=80\ \mu\text{m}$



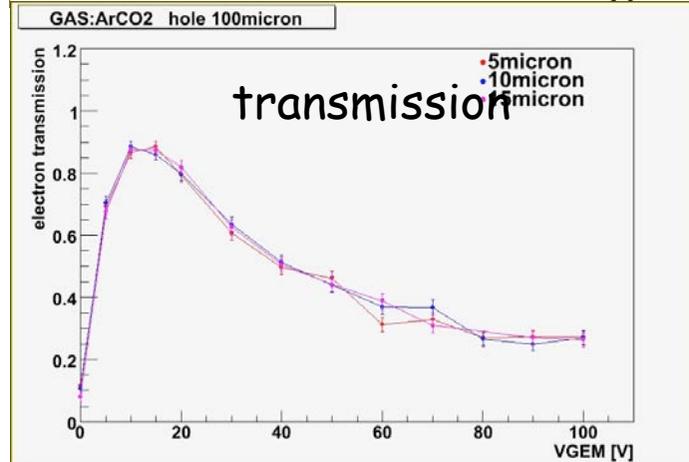
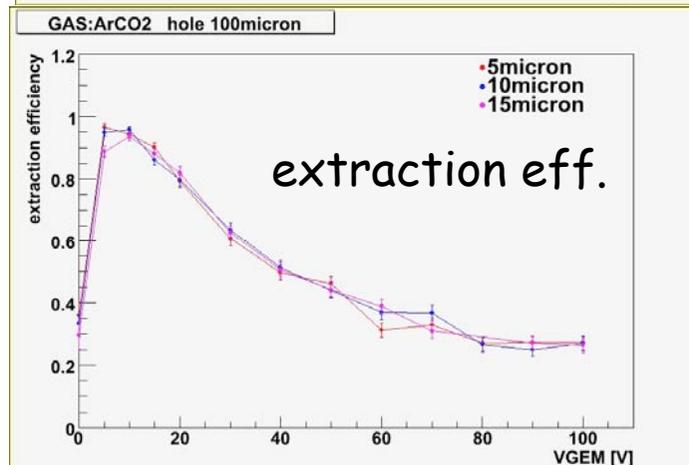
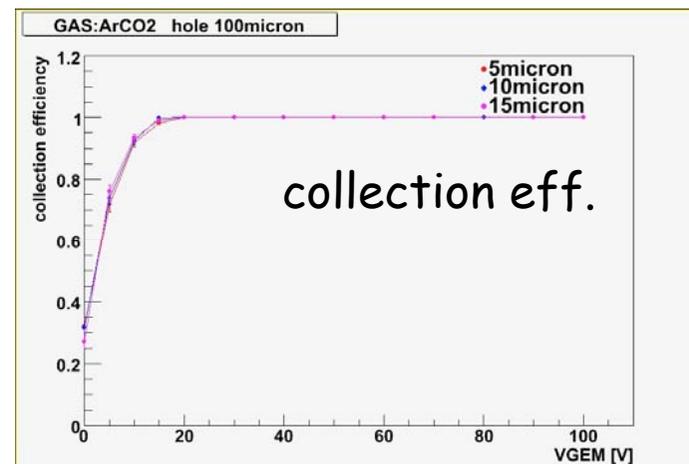
inner $\phi=70\ \mu\text{m}$



Hole shape is not a matter !
Over etching will be also not a matter
under low E field

We are going to study
hole size/pitch & GEM thickness

and
we have to measure it experimentally.



Summary

Serious studies for LC-TPC are on-going @ world-wide LC-TPC collaboration

“Proof of principle” has been studied with small prototype test.

Large Prototype project has started

Field Cage/Endplate/Electronics/Gas/Calibration/Monitor/DAQ/Software/.....

GEM is the alternative candidate for LC-TPC sensor

and also a candidate for ion-blocking gate

Japanese group is working for this now

We have to study many more basic things as well

dense ions effect in MPGD

(discharge/trip) recovery from unexpected local dense ionization hits

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